

# ICALEO®

31<sup>st</sup> INTERNATIONAL CONGRESS ON  
APPLICATIONS OF LASERS & ELECTRO-OPTICS

**September 23-27, 2012**

*Anaheim Marriott Hotel | Anaheim, California, USA*

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## Advance Program

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*Stefan Kaierle*, Laser Zentrum Hannover e.V., Hannover, Germany

### LASER MICROPROCESSING CONFERENCE CHAIR:

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*Xianfan Xu*, Purdue University, West Lafayette, IN, USA

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*Ken Dzurko*, SPI Lasers, Santa Clara, CA, USA

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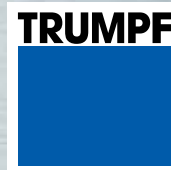


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September 23-27, 2012

Anaheim Marriott Hotel



Welcome!

**Congress General Chair Welcome**

**Kunihiro Washio**, *Paradigm Laser Research Limited, Tokyo, Japan*

**HELLO AND WELCOME!** The 31<sup>st</sup> International Congress on Applications of Lasers & Electro-Optics (ICALEO® 2012) is returning to the West Coast and the Anaheim Marriott Hotel in the heart of the Anaheim Resort District in Orange County, California. Continuing a tradition that began 30 years ago, the ICALEO Program Committee has put together a strong program with an impressive amount of contributions. As always, ICALEO provides an excellent arena in which to meet, collaborate, network and re-connect with colleagues and friends.

ICALEO 2012 will offer three conferences covering a continuously expanding array of laser applications:

**The Laser Materials Processing Conference (LMP)**, organized by Stefan Kaierle, continues its theme on high speed, efficient and flexible macroscopic laser processing applications, equipment and systems. The progress in high brightness processes brought on by advances and improvements in high power fiber, disk and direct diode lasers will be prominently featured.

**The Laser Microprocessing Conference (LMF)**, organized by Henrikki Pantisar, will cover processes and systems for microscopic applications—especially those that take advantage of the small feature sizes and high precision offered by picosecond and femtosecond ultrafast lasers and wavelength optimization. The LMF conference will feature a variety of application-oriented sessions highlighting the versatility of laser microprocessing, such as advanced lasers and optics in energy generation and storage, efficient and high-quality thin smart devices, high-quality lighting devices, next-generation medical devices and biomedical applications, etc.

**The Nanomanufacturing Conference (Nano)**, organized by Yongfeng Lu and Xianfan Xu, will explore topics in the emerging, and rapidly advancing, field of nanotechnology, as well as the role various lasers can play.

The Opening Plenary session will address the following topics: green photonics, recent progress and the application of light sources in material processing. The keynote address will be given on “Recent Status and Future Prospects of Global Research on Green Photonics” by Thomas Baer,

Executive Director of the Photonics Research Center at Stanford University. Other plenary session presentations will cover high-power material processing, laser-based microprocessing equipment for electronics industries and laser-produced plasma EUV light sources for nanolithography. This year's Closing Plenary session is organized by Michael Schmidt and will feature topics on ways that knowledge transfer can be used to stimulate the process of international knowledge exchange and cooperation between research institutions, as well as between research institutions and industry. In addition to the plenary sessions, ICALEO 2012 will have two sub-plenary sessions that will cover broader areas with organized invited talks by distinguished researchers. One of the sub-plenary sessions will be held within LMP alone. The other sub-plenary session held jointly by LMF and Nano, will help the audience members to increase their interdisciplinary knowledge and to develop valuable networking contacts.

**The Laser Solutions Short Courses**, organized by Silke Pflueger, are ideal for those who want to receive a complete overview on the state of the art in specific areas of interest to participants.

**The Business Forum and Panel Discussion** Chaired by Ken Dzurko, covers the challenging topic of increasing the role of lasers in a non-laser world. Following presentations by laser business leaders, a panel discussion will offer participants opportunities to interact with industry experts and to voice their own views.

The popular Vendor Reception allows attendees to learn about the latest products in the laser application market directly from industry representatives.

Anaheim is home to numerous attractions, including world-famous Disneyland, Disney's California Adventure, the Downtown Disney District and the Angels Stadium of Anaheim, with extensive shopping and dining options and spectacular nighttime entertainment. Combine this with a warm and comfortable climate, Anaheim is clearly an ideal location to experience ICALEO and more with colleagues, friends and family. With all of these great features and opportunities, I extend a warm invitation to all of you to come and take part in ICALEO 2012. See you in Anaheim, California!

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**Congress General Chair: Kunihiro Washio**

**LIA President: Reinhart Poprawe**

**LIA Executive Director: Peter Baker**

**LIA Director of Conferences: Gail Loiacono**

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# Plenary Session: Green Photonics and Recent Progress in Laser-Based Light Sources and Their Applications in Materials Processing

Session Chair: **Kunihiko Washio**, *Paradigm Laser Research Limited, Tokyo, Japan*

Monday, September 24 • 9:00am

Green photonics is becoming a key driver for profitable growth and well-being by contributing effective solutions for sustainability issues in the environment, economy and society. Laser-based light sources and their applications in macro-, micro- and nano-materials processing will be significant in advancing and promoting sustainable green photonics. The keynote speech by Thomas Baer, along with the other presentations by impressive leaders in their fields will make this one session you should not miss!

## Invited Plenary Speakers:

**Keynote Presentation – Recent Status and Future Prospects of Global Research on Green Photonics (OP1)**

Thomas Baer, *Stanford Univ., Stanford, CA, USA*

**High-Power Laser Materials Processing (OP2)**

Eckhard Beyer, *Fraunhofer IWS, Dresden, Germany*

**Laser-Based Microprocessing Equipment for Electronics Industries (OP3)**

Haibin Zhang, *ESI, Portland, OR, USA*

**LPP-EUV Light Source Development for High Volume Manufacturing Lithography (OP4)**

Hakaru Mizoguchi, *Gigaphoton, Inc., Oyama, Japan*

## Session Chair Appreciation Breakfast

Monday, September 24 • 7:30am

Session Chairs and Plenary Speakers are invited to the Session Chair Appreciation Breakfast on Monday, September 24 at 7:30am. Audio-Visual tips will be provided along with last minute updates and an overview of the week. Please plan to arrive in time to attend this important breakfast.

## ICALEO President's Reception Will Make a Grand Entrance!

**Marconi Automotive Museum**

Monday, September 24 • 5:30pm

ICALEO® will feature an evening reception hosted by LIA President Reinhart Poprawe at the greatly admired Marconi Automotive Museum. This unique automotive museum was first opened in 1994 and plays host to a 30 million-dollar collection of historical, exotic and classic cars.

Meet the LIA Officers, Board of Directors, ICALEO Congress General Chair and Conference Chairs while being surrounded by high-performance muscle cars and vintage formula racecars. You won't want to miss seeing Kenny Berstien's record breaking "Louie the Lizard" top fuel dragster, one of the five produced 1999 Jaguar XJ-220S and the one-of-a kind Ferrari FX.

This reception promises to be a memorable one. Join the LIA staff and friends in the winner's circle honoring your LIA President at the Marconi Automotive Museum.



## Welcome Celebration

Sunday, September 23 • 4:00pm

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Plan to arrive early and enjoy live entertainment provided by Beer's Law. In addition, free door prizes will be raffled! This event is a great opportunity for new attendees to meet "old timers" and for everyone to socialize and interact.



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# LIA Annual Meeting & Awards Luncheon featuring the Arthur L. Schawlow Award Presentation

Wednesday, September 26

Luncheon Sponsored by:



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## The 2012 Arthur L. Schawlow Award is presented to: Isamu Miyamoto

Isamu Miyamoto started research work in laser material processing in 1965 with developing high power CO<sub>2</sub> lasers at Osaka University and applied this for R&D of laser-matter interaction. Since then he has been involved in different types of laser materials processing using CW to ultrashort laser pulses, publishing more than 300 papers. He is currently Emeritus Professor of Osaka University and Guest Professor of Erlangen SAOT. Professor Miyamoto will give a presentation on the "Origin and New Wave of Laser Welding".

Laser Institute of America first presented the Arthur L. Schawlow Award in 1982 to recognize individuals who have made distinguished contributions to applications of lasers in science, industry or education. The Award presentation consists of a silver medal, a \$2,000 cash award and a citation. Awardees become Lifetime Members of LIA.

### About Arthur L. Schawlow

Professor Schawlow received a Nobel Prize for Physics in 1981 for "his contribution to the development of laser spectroscopy." He co-authored, along with Professor Charles H. Townes, the book Microwave Spectroscopy, and the first paper describing optical masers. For this latter work, the pair were awarded the Stuart Ballantine Medal by the Franklin Institute (1962) and the Thomas Young Medal and Prize by the Physical Society and Institute of Physics (1963). Professor Schawlow was also awarded the Morris N. Liebmann Memorial Prize by the Institute of Electrical and Electronic Engineers (1964). As the first honoree of this award in 1982, it is fitting that LIA's highest achievement award is given in Professor Schawlow's name.

## Closing Plenary Session: Ways of Knowledge Transfer

Session Chair: **Michael Schmidt, Bayerisches Laserzentrum GmbH, Erlangen, Germany**

Thursday, September 27 • 1:30pm

This year's ICALEO closing plenary session is organized by Michael Schmidt. Our long-term target is the mutual understanding of country specific research cultures to stimulate the process of international knowledge exchange and cooperation between research institutions as well as between research institutions and industry. The goal of this closing plenary session is to introduce different country-specific ways of transferring knowledge in order to spark interest in this topic. After the keynote speech by Isamu Miyamoto on "Study on the German Laser Centers," six distinguished researchers from around the world will discuss their regional methods of transferring knowledge.

### Keynote Presentation – Study on the German Laser Centers (C101)

Isamu Miyamoto, *Osaka Univ., Osaka, Japan*

### The American Way of Knowledge Transfer (C102)

Jyoti Mazumder, *CLAIM, The Univ. of Michigan, Ann Arbor, MI USA*

### The Canadian Way of Knowledge Transfer (C103)

Pierre Galarneau, *National Optics Institute (INO), Quebec, Canada*

### The Brazilian Way of Knowledge Transfer (C104)

Walter Weingaertner, *Univ. Federal de Santa Catarina, Florianopolis, Santa Catarina, Brazil*

### The Japanese Way of Knowledge Transfer (C105)

Hirofumi Niino, *National Institute of Advanced Industrial Science and Technology (AIST) AIST, Tsukuba, Japan*

### The European Way of Knowledge Transfer (C106)

Andreas Ostendorf, *Ruhr-Univ. Bochum, Bochum, Germany*





# Laser Materials Processing Conference

Conference Chair: **Stefan Kaierle**, *Laser Zentrum Hannover e.V., Hannover, Germany*

ICALEO® continues to be one of the most important laser events every year. This is well reflected by one of the highest numbers of abstracts for the LMP conference ever received so far. Once again, many researchers from all over the world have submitted their latest research results to be presented at ICALEO. The LMP conference program is full of excellent contributions covering 19 sessions in many different application fields, including a new format of a sub-plenary session. Major fields of applications are rapid prototyping processes like selective laser melting and laser metal deposition and welding, including combination processes and processing of dissimilar materials. Laser surface treatment, process control and modeling and simulation are further topics to be addressed.

While already being an indispensable tool in vast fields of industrial application, the laser, with its abundant number of applications, still experiences important progress in terms of research. Laser processes continuously cross new borders driven by the application demands from industry. At ICALEO, you can be in the first row to discover latest research results covered from fundamental to application driven topics. You are cordially invited to enjoy these opportunities and network with other researchers and delegates.

## LMP Session 1: Pulsating Topics in Laser Materials Processing

**September 24, 2012 • 1:30pm**

*Session Chair: Stefan Kaierle, Laser Zentrum Hannover e.V., Hannover, Germany*

### The State of Laser Additive Manufacturing (LAM) – Invited Presentation (101)

*Paul Denney, Lincoln Electric Company*

### LAM for Medical Applications – Invited Presentation (102)

*Christian Noelke, Laser Zentrum Hannover e.V.*

### Modeling of Keyhole Formation in Laser and Laser Arc Hybrid Welding Based on CFD Simulations – Invited Presentation (103)

*Suck-Joo Na, KAIST*

### Some Answers to Frequently Asked Questions and Open Issues of Laser Beam Cutting – Invited Presentation (104)

*Dirk Petring, Fraunhofer ILT*

## LMP Session 2: Laser Drilling

**September 24, 2012 • 3:20pm**

*Session Chair: Noemie Dury, LASAG AG, Thun, Swaziland*

### Drilling with Pulse Shaping by Using Fiber Lasers (201)

*Jens Dietrich, Ingomar Kelbassa, Hermann Uchtmann, Lehrstuhl fuer Lasertechnik RWTH Aachen*

### Development of an Azimuthally Polarized All-in-One Pulsed CO<sub>2</sub> Laser for Microdrilling (202)

*Masamori Endo, Tokai Univ.; Ryoji Koseki, Motoi Sasaki, Shibuya Kogyo Co., Ltd.*

### Comparison of Keyhole Characteristics Obtained by Two Experimental Methods: The "Direct Observation of Drilled Hole" Method and the "Sandwich" Method (203)

*Simone Mattei, Jean-Marie Jouvard, Massaud Mostafa, Henri Andrzejewski, Iryna Tomashchuk, Univ. of Burgundy*

### Simulation of Laser Drilling Process with the Constraint Natural Element Method (204)

*Girardot Jeremie, Illoul Lounes, Lorong Philippe, Ranc Nicolas, Favier Veronique, Schneider Matthieu, Berthe Laurent, PIMM Laboratory, Arts et Métiers ParisTech; Chinesta Francisco, GeM, Centrale Nantes*

## LMP Session 3: Laser Metal Deposition I

**September 24, 2012 • 3:20pm**

*Session Chair: Wolfgang Knapp, CLFA Fraunhofer ILT, Paris, France*

### Laser-Assisted Development of New Ti-Mo-Zr Alloys for Biomedical Applications (301)

*Amelia Almeida, Carole Loable, Rui Vilar, Instituto Superior Tecnico*

## Special Thanks to the ICALEO International Advisory Board:

**David Belforte**, Industrial Laser Solutions, Sturbridge, MA, USA  
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**Antti Salminen**, Lappeenranta Univ. of Technology, Lappeenranta, Finland  
**Rudolf Weber**, IFSW Univ. of Stuttgart, Stuttgart, Germany

**Residual Stress Control in DMD Process (302)***Hyung Min Chae, Univ. of Michigan***3D Analysis of The Powder Flow of Laser Cladding Nozzles (305)***Rezak Mezari, Pascal Aubry, Thierry Malot, Kevin Verdier, Arts et Métiers ParisTech***A Verified Model of Transient and Residual Stresses in Laser Direct Metal Deposition (304)***Michael Vogel, Mushtaq Khan, Juansethi Ibarra-Medina, Andrew J Pinkerton, Manufacturing and Management Group, School of Mechanical, Aerospace and Civil Engineering, The Univ. of Manchester; Narcisse N'Dri, Mustafa Megahed, ESI GmbH***LMP Session 4: Laser Processing of CFRP****September 25, 2012 • 8:30am***Session Chair: Uwe Stute, Laser Zentrum Hannover e.V., Hannover, Germany***Remote Processing of Tailored Fiber Reinforced Lightweight Structures (401)***Andreas Furst, TU Dresden; Annett Klotzbach, Fraunhofer IWS***Laser-Based Hot-Melt Bonding of CFRP and GFRP - A Novel Joining Technology for Multi Material Design (402)***Philipp Amend, Bayerisches Laserzentrum GmbH; Thomas Frick, Bayerisches Laserzentrum GmbH; Erlangen Graduate School in Advanced Optical Technologies; Michael Schmidt, Bayerisches Laserzentrum GmbH; Chair of Photonic Technologies, Univ. of Erlangen-Nuremberg; Erlangen Graduate School in Advanced Optical Technologies***Experimental and Numerical Analysis of Laser Beam Transmission in Continuous Fiber Thermoplastic Composites (403)***Wolfgang Knapp, CLFA Fraunhofer ILT***Influence of Different Ambient Media on the Laser Ablation Process of CFRP (404)***Christian Freitag, Margit Hafner, Volkher Onuseit, Rudolf Weber, Thomas Graf, IFSW***Laser Joining of Through Thickness Reinforced Glass Fiber Composite Pre-Forms (405)***Gen Satoh, Huade Tan, Lawrence Yao, Columbia Univ.***Advantages and Challenges of CFRP Laser Machining with ns Pulses (406)***Hagen Dittmar, Sven Bluemel, Peter Jaeschke, Uwe Stute, Dietmar Kracht, Laser Zentrum Hannover e.V.***Latest Results in Laser Cutting of Carbon Fiber Reinforced Plastics (407)***Stephan Ziermann, David Havrilla, TRUMPF, Inc.; Nicolai Speker, TRUMPF Laser-und Systemtechnik GmbH; Christian Koerber, TRUMPF GmbH+Co. KG***Simulation of Laser Ablation of CFRP (408)***Christian Freitag, Thomas Graf, Margit Hafner, Andreas Michalowski, Volkher Onuseit, Rudolf Weber, Univ. Stuttgart, IFSW***Laser Surface Pre-Treatment of CFRP for Adhesive Bonding (409)***Fabian Fischer, Stefan Kreling, Klaus Dilger, Institute for Joining and Welding, Univ. of Braunschweig***LMP Session 5: Laser Metal Deposition II****September 25, 2012 • 8:30am***Session Chair: Ingomar Kelbassa, RWTH Aachen Univ., Aachen, Germany***A Study of the Effect of Angle of Beam Incidence on Ytterbium Fiber Laser Cladding of Alloy 625 (501)***Gerald Bruck, Brandon Shinn, Ahmed Kamel, Siemens***Single Crystal (SX) Laser Cladding of CMSX-4 (502)***Boris Rottwinkel, Christian Noelke, Michael Hustedt, Stefan Kaieler, Volker Wesling, Laser Zentrum Hannover e.V.; Nils Weidlich, MTU Maintenance Hannover GmbH***Comparison of Metal Matrix Nanocomposite and Microcomposite Layers on AISI H13 Tool Steel Surface by Addition of TiC Nanoparticles and Microparticles by Laser Cladding (503)***Vicente Rouco, M. Angeles Montealegre, Pilar Rey, Gemma Castro, Marcos Gonzalez, Jorge Arias, AIMEN***Calculating the Stress of Multi-Track Formations in Induction-Assisted Laser Cladding (504)***Frank Brueckner, Dietrich Lepski, Steffen Nowotny, Fraunhofer IWS; Christoph Leyens, Eckhard Beyer, Fraunhofer IWS / Dresden Univ. of Technology***An Investigation of Powder Properties on Some Coating Features of Alloy 625 Coatings Deposited by Laser Cladding (505)***Jonne Nakki, Tampere Univ. of Technology***In-Situ Synthesis of Cr13Ni5Si2 Reinforced Metal Matrix Composite Coatings by Laser Induction Hybrid Cladding (506)***Dengzhi Wang, Qianwu Hu, Xiaoyan Zeng, Wuhan National Laboratory for Optoelectronics***Recent Developments in High Power Laser Cladding Techniques (507)***Jari Tuominen, Jonne Näkki, Henri Pajukoski, Petri Vuoristo, Tampere Univ. of Technology, Department of Materials Science; Tuomo Peltola, Technology Centre Ketek Ltd.***Synthesis of Functionally Gradient TiC Reinforced Nickel Metal Matrix Composites by Laser Direct Deposition with Characterization of Properties (510)***Jon Michael Wilson, Yung Shin, Purdue Univ.***Structure of Ni-Alloys Deposited by Laser Powder Deposition on Single Crystal Superalloy Substrates (509)***Rui Vilar, Instituto Superior Técnico***LMP Session 6: Process Monitoring & Control****September 25, 2012 • 8:30am***Session Chair: Markus Kogel-Hollacher, Precitec Optronik GmbH/Precitec KG, Rodgau, Germany***X-Ray and Optical Videography for Quantitative Measurement of 3D Geometries of Capillary and Melt Pool in Laser Keyhole Welding (601)***Felix Abt, Thomas Graf, Rudolf Weber, IFSW***Process Monitoring and Control for Laser Based Thin Film Treatment (602)***Christian Vedder, Fraunhofer ILT***In-Situ Penetration Depth Control for Laser Welding of Coated and Uncoated Steel Using Spectroscopy (603)***Ali Riza Konuk, Ronald Aarts, Bert Huis in't Veld, Univ. of Twente***Detection of Faults in Laser Beam Welds by Near-Infrared Camera Observation (604)***Holger Braun, Friedhelm Dorsch, Steffen Kessler, Dieter Pfitzner, Volker Rominger, TRUMPF Laser-und Systemtechnik GmbH***Comprehensive Monitoring and Control of Laser Hybrid Arc Welding in Industrial Production (605)***Alexander Kaplan, Jan Karlsson, Luleå Univ. of Technology***Diagnostics of the CO<sub>2</sub> Laser Cutting Process Evaluating the Back Reflected Laser Power (606)***David Schindhelm, Rudolf Weber, Thomas Graf, IFSW***Analysis of Coaxial Vision Systems for Real-Time Z-Height Control for Laser Cladding Process (607)***Rezak Mezari, Thierry Malot, Kevin Verdier, Pascal Aubry, Arts et Métiers ParisTech***Ultrasonic Waves Detection by Electronic Speckle Pattern Shearing Interferometry for Aircraft Components (608)***Enrique Pineiro, Alberto Asensio, Francisco Rodriguez, AIMEN***The Study About the Algorithm of the Detecting Feature on Weld Images During Laser Welding Processes (609)***Duan Aiqin, Wang Bin, Chen Xinsong, BAMTRI*

**LMP Session 7: Welding I****September 25, 2012 • 1:30pm***Session Chair: Antti Salminen, Lappeenranta Univ. of Technology, Lappeenranta, Finland***Electromagnetic Control of the Weld Pool Dynamics in Partial Penetration Laser Beam Welding of Aluminium Alloy (701)***Vjaceslav Avilov, Andre Schneider, Marco Lammers, Andrey Gumenyuk, Michael Rethmeier, Federal Institute for Materials Research and Testing (BAM)***Laser-Welded Sandwich Floor for Marine Container (702)***Ilpo Maaranen, Ruukki Metals Oy; Jukka Siltanen, Rautaruukki Oyj***Measuring Laser Weldability of Aluminum Alloys:****The Controlled Restraint Weldability Test (703)***Nicolas Coniglio, Mario Patry, Patrick Gougeon, CTA-CNRC***Tube-to-Tubesheet Laser Welding with Vision (704)***Stan Ream, EWI***Investigation of Laser Shock Processing on Titanium Alloys by Linear Friction Welding (705)***Zhigang Che, Shuili Gong, BAMTRI***Twinquasi - A New Method for Quasi-Simultaneous Laser Welding of Polymers (706)***Saara Ruotsalainen, Petri Laakso, Veli Kujanpää, VTT Technical Research Centre of Finland; Tuomas Purtonen, Matti Manninen, Antti Salminen, Lappeenranta Univ. of Technology***Controllable Beam Intensity Profile for the Tasks of Laser Material Processing (707)***Alexander Laskin, Vadim Laskin, AdIOptica GmbH***LMP Session 8: Laser Cutting****September 25, 2012 • 1:30pm***Session Chair: Eckhard Beyer, Fraunhofer IWS, Dresden, Germany***A Technical and Commercial Comparison of Fiber Laser and CO<sub>2</sub> Laser Cutting (801)***John Powell, Alexander Kaplan, Luleå Univ. of Technology***Impact of Thermal Focal Shift on Laser Cutting Processes with High Brightness Lasers (802)***Sasia Eiselen, Bayerisches Laserzentrum GmbH; Erlangen Graduate School in Advanced Optical Technologies, Univ. Erlangen-Nuremberg; Heiko Zapf, Eugenia Mantel, Bayerisches Laserzentrum GmbH; Lukas Hofmann, Chair of Photonic Technologies, Univ. Erlangen-Nuremberg; Michael Schmidt, Chair of Photonic Technologies, Erlangen Graduate School in Advanced Optical Technologies, Univ. Erlangen-Nuremberg; Bayerisches Laserzentrum GmbH***Identification and Characterization of Analogies of Remote Fusion Cutting Processes Using Different Beam Sources (803)***Matthias Luetke, Alexander Wagner, Andreas Wetzig, Eckhard Beyer, Fraunhofer IWS; Jan Musiol, Michael F. Zaeh, Institute for Machine Tools and Industrial Management (IWB), Technische Univ. Muenchen (TUM)***High Efficiency Laser Oxygen Thick Section Cutting of Mild Steels Using Disk Laser (804)***Tao Zhang, Institute of Scientific and Technical Information of China; William O'Neill, Institute for Manufacturing, Univ. of Cambridge***Mass and Momentum Transfer of Oxygen Jet to the Melt in Laser Cutting of Mild Steel (805)***Grigoriy Ermolaev, Alexander Zaitsev, ITAM SB RAS***Advanced Laser Cutting Technology for Sheet Metal by High Power Fiber Laser (806)***Hiroaki Ishiguro, Hiroshi Sako, Amada Co., Ltd.; Dahv Kliner, Martin Muendel, JDSU***Process-Reliable and Cost-Effective Laser Materials Processing (807)***Peter Bruns, Marco Lentjes, Vitalij Lissotschenko, Klaus Reinecke, Michael Voss, LIMO Lissotschenko Mikrooptik GmbH***LMP Session 9: High Brightness Lasers & Systems****September 25, 2012 • 1:30pm***Session Chair: Kerstin Kowalick, Ruhr Univ. Bochum, Bochum, Germany***Mid Infra-Red Fiber Laser Developments and Applications (901)***Tony Hault, IPG Photonics Corporation***Fiber-Coupled High Power Stabilized Green Laser for Material Processing Applications (902)***Berthold Burghardt, Johannes Richter, Innovavent GmbH; Nick Hay, Ian Baker, Stuart Bashford, Yili Guo, Young Kwon, Powerlase Photonics Ltd.; Jong-Kab Park, EO Technics Co., Ltd.***High Power Disk Lasers - Advances & Applications (903)***David Havrilla, Tracey Ryba, TRUMPF Inc.; Marco Holzer, TRUMPF Laser-und Systemtechnik GmbH***102 W All-Fiber Broadband Superfluorescent Source Based on Ytterbium-Doped Double-Cladding Fibers (904)***Yi Cao, Jiang Liu, Ke Wang, Pu Wang, Beijing Univ. of Technology***Investigation of Thermal Lensing Time Constants in Laser Processing Optics (905)***Christiane Thiel, Axel Hess, Rudolf Weber, Thomas Graf, IFSW***UV Line Beam Laser Optics for Material Processing (906)***Denis Bolshukhin, Berthold Burghardt, Hans-Juergen Kahlert, Innovavent GmbH; Nick Hay, Young Kwon, Powerlase Photonics Ltd.; Jong-Kab Park, EO Technics Co., Ltd.***All Passive Optical Design Laser Beam Analyzer for High Power CO<sub>2</sub> Lasers (907)***Michael Scaggs, Gilbert Haas, Haas Laser Technologies, Inc.***LMP Session 10: Welding II****September 26, 2012 • 8:30am***Session Chair: Ali Khan, TWI Ltd, Cambridge, Great Britain***The Influence of the Pressure of Ar Shielding Gas on the Keyhole Behavior During CO<sub>2</sub> Laser Welding of TA15 (1001)***Aiqin Duan, Shuili Gong, BAMTRI***Studying on Characteristics of Plume/Plasma in Fiber Laser Welding and CO<sub>2</sub> Laser Welding (1002)***Rongshi Xiao, Jianglin Zou, Beijing Univ. of Technology***New Hot Cracking Criterion for Laser Welding in Close Edge Position (1003)***Peter Stritt, GSAME; Rudolf Weber, Thomas Graf, IFSW; Steffen Mueller, Jan-Philipp Weberpals, AUDI AG***Three-Dimensional Visualization of Melt Flows in Molten Pool During Laser Welding by X-Ray Transmission Real-Time Observation System (1006)***Ryoji Ido, Seiji Katayama, Yousuke Kawahito, Joining and Welding Research Institute of Osaka Univ.; Hiroshi Nakamura, Charmant Inc.***Time-Frequency Analysis of Pressure Oscillation Inside the Keyhole for Weld Quality Monitoring (1005)***Seung Lee, The Univ. of Michigan***LMP Session 11: Processing of Dissimilar Materials****September 26, 2012 • 8:30am***Session Chair: Milan Brandt, RMIT Univ., Bundoora Victoria, Australia***Local Laser Joining of Glass and Silicon (1101)***Assi Hansen, Jorma Vihinen, Tampere Univ. of Technology, Department of Production Engineering Yasuhiro Okamoto, Isamu Miyamoto, Osaka Univ.; Tiina Amberla, Corelase Ltd.***Laser Joining of Plastics with Metals (1102)***Jean Pierre Bergmann, Martin Stambke, Ilmenau Univ. of Technology***Dissimilar Metal Joining of Mg Alloy to Al Alloy by Laser Brazing Process (1103)***SookHwan Kim, Mok Young Lee, RIST***Brazing of 22MnB5 Hot-Dip Aluminized Steel with AlSi3Mn (1104)***Florian Schmidt, Frank Vollertsen, BIAS*

**Joining of Dissimilar Metal Tubes by Laser Autogenous Brazing (1105)**

Gen Satoh, Y. Lawrence Yao, Columbia Univ.; Syed Naveed, Boston Scientific Corporation

**LMP Session 12: Laser Surface Modification I**

**September 26, 2012 • 10:30am**

Session Chair: Juan Pou, Univ. de Vigo, Vigo, Spain

**Production of Conductive Paths by Laser Processing of Printed Nanoparticulate Materials (1201)**

Melanie Meixner, Jochen Stollenwerk, Konrad Wissenbach, Fraunhofer ILT

**Study on Cavitation Resistance and Wear Properties of TC4 Laser Alloyed with NiAl-VC Coatings (1202)**

Yao Jianhua, Zhejiang Univ. of Technology

**Effect of the Positions of Off-Focal Points on Alloy 600 Specimen Surface Morphology in a Laser Peening Process (1203)**

Chin-Man Chung, Joung Soo Kim, Korea Atomic Energy Research Institute

**Generic Parameters Governing the Biofunctionality of Laser Surface Engineered Nylon 6,6 (1204)**

Jonathan Lawrence, David Waugh, Univ. of Lincoln

**Process Map Approach to Laser Transformation Hardening of Carbon Steels (1205)**

Hyungson Ki, Sangwoo So, Ulsan National Institute of Science and Technology

**Laser Hardening of Gear Wheels (1206)**

Stanislav Nemecek, Matex PM

**LMP Session 13: Hybrid & Combination Processes I**

**September 26, 2012 • 10:30am**

Session Chair: Silke Pflueger, ULO Optics Inc., Los Gatos, CA, USA

**Double TIG Laser Aluminium Welding Process (1301)**

Alexander Barroi, Jörg Hermsdorf, Stefan Kaierle, Volker Wesling, Laser Zentrum Hannover e.V.

**Fundamental Investigations and Systems Engineering for Laser-Assisted Milling of Titanium Alloys (1306)**

Robert Wiedenmann, Michael F. Zaeh, IWB - Technische Univ. Muenchen

**Characterization of Hybrid Disk-Laser Welding of Titanium Alloy Ti-6Al-4V to Aluminum Alloy 2024 (1303)**

Vittorio Alfieri, Fabrizia Caiazza, Francesco Cardaropoli, Vincenzo Sergi, Univ. of Salerno

**A Comparative Study of Laser, CMT, Laser-Pulse MIG Hybrid and Laser-CMT Hybrid Welded Aluminium Alloy (1304)**

Chen Zhang, Ming Gao, Geng Li, Xiaoyan Zeng, Huazhong Univ. of Science and Technology

**Influence of Filler Metal and Mixing on Weld Microstructure of Laser/Hybrid Welded Thick Austenitic Stainless Steel Joints (1305)**

Miikka Karhu, Veli Kujanpaa, VTT-Technical Research Centre of Finland; Andrey Gumenyuk, Marco Lammers, BAM - Federal Institute for Materials Research and Testing

**Development and Experimental Analysis of Laser-Assisted Plasma Arc Welding (1302)**

Achim Mahrle, Michael Schnick, Sascha Rose, Thomas Pinder, Uwe Fuessel, Dresden Univ. of Technology; Eckhard Beyer, Fraunhofer IWS

**LMP Session 14: Welding III**

**September 26, 2012 • 3:00pm**

Session Chair: Magdi Azer, GE Global Research, Niskayuna, NY, USA

**Welding Battery Tabs for Electrified Vehicles (1401)**

Jay Eastman, EWI

**Zero-Gap Laser Welding of Zinc Coated Steels in a Lap Joint Configuration (1402)**

Shanglu Yang, General Motors China Science Lab

**X-Ray Videography Investigation of Keyhole in Laser Welding of Different Joint Geometries (1403)**

Mikko Vänskä, Lappeenranta Univ. of Technology, Institut fuer Strahlwerkzeuge, Univ. Stuttgart; Felix Abt, Rudolf Weber, Institut fuer Strahlwerkzeuge, Univ. Stuttgart; Antti Salminen, Lappeenranta Univ. of Technology, Machine Technology Center Turku Ltd; Thomas Graf, Institut fuer Strahlwerkzeuge, Univ. Stuttgart

**Development and Application of the 10kW Fiber Laser Welding System (1404)**

Yosuke Yamazaki, Osaka Univ., Joining and Welding Research Institute; Akikazu Kitagawa, Hitachi Zosen Corporation

**Comparison of Fiber Laser Model Distribution in Industrial Welding Applications (1405)**

Daniel Capostagno, SPI Lasers

**Bead Features in Laser Hybrid Lap Welding of Superalloys for Aerospace Application (1406)**

Fabrizia Caiazza, Vittorio Alfieri, Francesco Cardaropoli, Vincenzo Sergi, Univ. of Salerno

**LMP Session 15: Hybrid & Combination Processes II**

**September 26, 2012 • 3:00pm**

Session Chair: Jörg Hermsdorf, Laser Zentrum Hannover e.V., Hannover, Germany

**Combined Laser and Arc Welding of Thick-Section Stainless Steel Sheets (1501)**

Ahmed Elmeslamy, Lin Li, John Francis, The Univ. Manchester

**Laser-Arc Hybrid Welding of Thick-Section Mild Steel Plates: Microstructure and Performances of the Beads (1502)**

Geng Li, Ming Gao, Chen Zhang, Xiaoyan Zeng, Wuhan National Laboratory for Optoelectronics

**Laser-GMA Hybrid Welding of Direct Quenched Steel in Lap Joint Configuration - A Preliminary Study (1503)**

Miikka Karhu, Veli Kujanpaa, VTT Technical Research Centre of Finland; Jukka Siltanen, Rautaruukki Oyj, Corporate Functions

**High Power Laser Welding of Structural Steels (1504)**

Duncan Pratt, GE Global Research

**Laser GMA Hybrid Welding for Thick Wall Applications of Pipeline Steel with the Grade X70 (1505)**

Oliver Seffer, André Springer, Stefan Kaierle, Volker Wesling, Heinz Haferkamp, Laser Zentrum Hannover e.V.

**Diode Laser Hybrid Welding (1506)**

Brian Victor, Laserline, Inc.

**LMP Session 16: Laser Metal Deposition III**

**September 26, 2012 • 3:00pm**

Session Chair: Paul Denney, Lincoln Electric Company, Cleveland, OH, USA

**Challenges in the Design of Portable Laser Repair Systems (1601)**

Andrew Nissly, Todd Palmer, Edward Reutzel, ARL, The Penn State Univ.

**Adaptive Shape Control in Laser Metal Deposition by Adjusting Weld Pool Size (1602)**

Masanori Miyagi, Takeshi Tsukamoto, Hirotsugu Kawanaka, Hitachi, Ltd.

**A Novel Method of Pulsed Laser-Cladding for Effective Control of Melting of WC Particulates in NiCr-WC Composite Coatings (1603)**

Manish Tak, S. M. Shariff, Vikram Sake, Gade Padmanabham, (ARCI)

**Evaluation of Wear Properties of Laser Cladded MMC Coatings (1604)**

Jo Verwimp, Eric Geerinckx, Filip Motmans, Marleen Rombouts, VITO

**Effect of Processing Parameters on Microstructure and Mechanical Properties of Laser Deposited Inconel 718 Superalloy (1607)**

Guru Dinda, Kevin Alexander, Douglas Grant, Cherrell Franklin, Robert Ruokolainen, Ashish Dasgupta, Focus: HOPE

**Impact of Path Planning on Thermal History During Additive Manufacturing of Ti-6Al-4V (1606)**

Shawn Kelly, Todd Palmer, Edward Reutzel, ARL, The Penn State Univ.



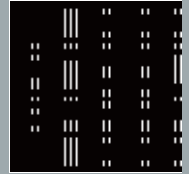
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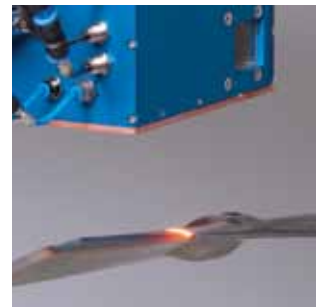


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### INVITATION

International Laser Symposium Fiber & Disc (FiSC 2012) and "Tailored Joining"  
October 16 - 18, 2012, International Congress Center Dresden, Germany

**LMP Session 17: Welding IV****September 27, 2012 • 8:30am***Session Chair: Dirk Petring, Fraunhofer ILT, Aachen, Germany***Effect of Gas Shielding and Heat Input on Autogenous Welding of Duplex Stainless Steel (1701)***Antti Salminen, Lappeenranta Univ. of Technology***High-Quality Laser Welding of Copper Using Appropriate Power Modulation (1702)***Andreas Heider, Rudolf Weber, Thomas Graf, IFSW***Laser Butt Welding for Tailor-Welded Blanks with Hot Press Forming Steel (1703)***Minjung Kang, Cheolhee Kim, KITECH***Spatter-Free Fast Welding with Single Mode Fiber Laser for Magnesium Alloy Sheet (1704)***Mok-Young Lee, RIST***Research on Welding and Heat Treatment of High-Chromium Ferritic Stainless Steel (1705)***Yongqiang Zhang, Jun Zhang, Wei Wang, Xi Zhang, Shukun Mu, Shougang Research Institute of Technology; Lintao Xi, Ping Chen, Beijing Shougang Gitane New Materials Co. Ltd***Optimization of Laser Welding Parameters of ZEK100 Magnesium Alloy in Lap Joint Configuration (1706)***Masoud Harooni, Fanrong Kong, Radovan Kovacevic, Southern Methodist Univ.; Blair Carlson, General Motors***Meeting Quality Criteria When Laser Welding of Alloy 718 (1707)***Chris Allen, Jon Blackburn, Paul Hilton, Ali Khan, TWI Ltd***Influence of Surface Condition in Fiber Laser Welding of Pure Copper (1708)***Guijun Bi, Hui-Chi Chen, Sharon Mui Ling Nai, Jun Wei, Singapore Institute of Manufacturing Technology***Formation Mechanism of Process Instabilities and Strategies to Improve Welding Quality (1709)***Volker Rominger, Thomas Harter, TRUMPF Laser-und Systemtechnik GmbH; Rudolf Weber, Thomas Graf, IFSW***LMP Session 18: Laser Surface Modification II****September 27, 2012 • 8:30am***Session Chair: Lin Li, The Univ. of Manchester, Manchester, Great Britain***Advances in Large-Scale Laser Paint Stripping (1801)***Stan Ream, EWI***Single-Pulse Control of Ablation by Monitoring Response of Target Material (1802)***Sergey Broude, Chen-Hsiung Cheng, Resonetics***Analysis of Material Removal on Metallic Materials by Pulsed Fiber Lasers (1803)***Mark Brodsky, SPI Lasers***Laser Cleaning of Graffiti from Building Stone Using High Power Diode Laser (1804)***Joaquin Penide, Felix Quintero, Rafael Comesana, Jesus Del Val, Fernando Lusquinos, Juan Pou, Dpto. Fisica Aplicada, Univ. of Vigo; Antonio Riveiro, Centro Univ. de la Defensa; Amadeo Sanchez-Castillo, Facultad de Ingenieria Mecanica, Univ. Michoacana de San Nicolas de Hidalgo***Characterization of the Corrosion Performance of Aluminium Laser Alloyed with Stellite 6 and Zirconium Powders (1805)***Sisa Pityana, Center for Scientific and Industrial Research, National Laser Centre.; Patricia Popoola, Tshwane Univ. of Technology***Characterization of Protective Layers Produced by Laser Treatment (1806)***Vaclav Ocelik, Ismail Hemmati, M2I/Univ. Groningen; Jeff Th.M. De Hosson, Department of Applied Physics, Univ. of Groningen***Surface Glazing of Concrete Using Lasers for Protection and Decommissioning (1807)***Jonathan Lawrence, Univ. of Lincoln***Microstructure Evaluation of A356 Aluminium Alloy Laser Surface Alloyed with Ni-Ti-SiC and Ni-Ti-C (1808)***Clayton D' Amato, Maurizio Fenech, Joseph Buhagiar, John C. Betts, Univ. of Malta***On the Interaction of the Particles of Tantalum with a Substrate of Copper in the Cold Spray Bonding Process (1809)***Nifa Anass, Laurent Berthe, Michel Boustie, Laure-Line Descurnings, CNRS***LMP Session 19: Modelling & Simulation****September 27, 2012 • 8:30am***Session Chair: Remy Fabbro, PIMM Laboratory, Arts et Métiers ParisTech - CNRS, Paris, France***Three-Phase 3D Modelling of a Laser Cutting Process Using Smoothed Particle Hydrodynamics (SPH) (1901)***Lin Li, Noorhafiza Muhammad, Benedict Rogers, The Univ. of Manchester***Numerical Simulation of Cut Kerf Formation Under the Influence of CO<sub>2</sub> and Fiber Lasers Radiation (1902)***Aleksandr Zaitsev, Grigoriy Ermolaev, Alexey Gurin, ITAM SB RAS***Modelling of Cutting Velocity Influence on the Kerf Front During Laser Cutting Process (1903)***El-Hachemi Amara, Centre for Development of Advanced Technologies; Remy Fabbro, PIMM Laboratory (Arts et Métiers ParisTech-CNRS); Koji Hirano, Nippon Steel Corporation***Thermohydraulic Aspects in Laser Welding and Cutting Processes (1904)***Toshiharu Muramatsu, Japan Atomic Energy Agency***The Numerical Simulation of Heat Transfer During a Hybrid Laser-MIG Welding of Duplex Steel (1905)***Issam Bendaoud, Henri Andrzejewski, Alexandre Mathieu, Simone Mattei, Pierre Sallamand, Iryna Tomashchuk, Interdisciplinary Laboratory Carnot of Burgundy, Univ. of Burgundy; Eugen Cicala, Mechanical Engineering Faculty, Polytechnic Univ. of Timisoara; Amelie Fanica, Material Research Centre of Creusot, Arcelor Mittal France/Industeel***Study on Temperature Dependence of Recoil Pressure Near the Boiling Temperature - Towards Better Modeling and Simulation (1909)***Koji Hirano, Nippon Steel Corporation; Remy Fabbro, Maryse Muller, PIMM Laboratory, Arts et Métiers ParisTech - CNRS***Modeling Keyhole and Weld Pool Dynamics of Laser Welding Under Variable Ambient Pressure (1906)***Shengyong Pang, State Key Laboratory of Materials Processing and Die & Mould Technology, Huazhong Univ. of Science & Technology; Koji Hirano, Nippon Steel Corporation; Remy Fabbro, PIMM Laboratory, Arts et Métiers ParisTech - CNRS***Three-Dimensional Dynamic Modeling of Keyhole During Pulse Laser Welding (1907)***Wenda Tan, Yung Shin, Purdue Univ.***Towards a Quantitative Model for Porosity Predication in CO<sub>2</sub> Laser Welding of Titanium Alloy Sheets (1908)***Shengyong Pang, Weidong Chen, Lunji Hu, Huazhong Univ. of Sci. & Tech.*



# Laser Microprocessing Conference

Conference Chair: **Henrikki Pantsar, Cencorp Oyj, Salo, Finland**

The Laser Microprocessing Conference will present an in-depth view into the evolving world of micro-scale laser applications, innovative optics and advances in laser sources. Development in this growing field is fast-paced, and the ICALEO® congress is the place to visit to see and hear the state of the art in applied research and gain knowledge of development trends. Technologies presented in this conference will be the drivers for efficient manufacturing and sustainable growth in the future.

The Laser Microprocessing Conference comprises more than 80 technical and invited papers, featuring a wide spectrum of applications from biomedical to energy generation and storage. In 2012, there is a great deal of emphasis on processing of various materials, such as thin films, CFRP and transparent materials. The importance of laser surface engineering is increasing, and new laser sources and optical concepts have been developed for more cost efficient manufacturing and better quality. In addition, other aspects of micromachining and joining, as well as physical interactions and monitoring solutions, are well covered. Overall, this year's Laser Microprocessing Conference offers a balanced mixture of innovation, science and technology transfer, setting the stage for an exciting ICALEO congress, full of enthusiasm, leading edge technology and networking.

## LMF Session 1 (Joint with Nano Conference): World of Applications in Sub-Millimeter Scale September 24, 2012 • 1:30pm

Session Co-Chairs: **Henrikki Pantsar, Cencorp Corporation, Canton, MI, USA;** **Yongfeng Lu, Univ. of Nebraska-Lincoln, Lincoln, NE, USA**

### Combination of Photonics and Nano Technology - New Possibilities for Micro and Macro Applications - Invited Presentation (M101)

**Michael Schmidt, Bayerisches Laserzentrum GmbH**

### Overview on How to Integrate Difference Scales in Laser Material Processing – Invited Presentation (M102)

**Lin Li, The Univ. of Manchester**

## LMF Session 2: Medical Devices and Biomedical Applications

September 24, 2012 • 3:20pm

Session Chair: **Xiaoyan Zeng, Huazhong Univ. of Science & Technology, Wuhan, People's Republic of China**

### Variation of Biocompatibility of Titanium Dioxide Film by Femtosecond Laser Irradiation (M201)

**Togo Shinonaga, Naoto Horiguchi, Yuichiro Ito, Nobuyuki Abe, Masahiro Tsukamoto, Osaka Univ.; Takao Hanawa, Akiko Nagai, Kimihiro Yamashita, Institute of Biomaterials and Bioengineering, Tokyo Medical and Dental Univ.**

### Femtosecond Laser Surface Processing of Platinum (M202)

**Stephen Brown, Andrew Fisk, Pulse Technologies; Edward Reutzel, ARL, The Penn State Univ.**

### Femtosecond Laser Manufacturing of Intraocular Implants (M203)

**Paul-Etienne Martin, Axel Kupisiewicz, Lasea; Christophe Pagnouille, Physioli; Eric Mottay, Amplitude Systemes**

### Effect of Laser Induced Crystallinity Modification on Biodegradation Profile of Poly(L-Lactic Acid) (M204)

**Shan-Ting Hsu, Y. Lawrence Yao, Columbia Univ.**

## LMF Session 3: Innovative Laser Optics September 25, 2012 • 8:30am

Session Chair: **Stefan Heinemann, Fraunhofer CLT, Plymouth, MI, USA**

### Multiple NUV Beam Internal Structuring of Materials Using a Phase-Only Spatial Light Modulator (M301)

**Dun Liu, Zheng Kuang, Walter Perrie, Stuart Edwardson, Geoff Dearden, Ken Watkins, Univ. of Liverpool**

### Surface Ultrafast Laser Micro-Patterning of Silicon Using Diffractive Multi-Beam Patterns (M302)

**Zheng Kuang, Dun Liu, Walter Perrie, Stuart Edwardson, Geoff Dearden, Ken Watkins, Univ. of Liverpool**

### Picosecond Laser Beam Shaping Using a Spatial Light Modulator (M303)

**Dun Liu, Zheng Kuang, Leigh Mellor, Walter Perrie, Stuart Edwardson, Geoff Dearden, Ken Watkins, Univ. of Liverpool**

### All Solid-State Picosecond Passively Mode-Locked Laser (M310)

**Junjie Chi, Beijing Univ. Of Technology**

### Creating Flattop Square Laser Spots in Microprocessing Systems with Scanning Optics (M305)

**Alexander Laskin, Vadim Laskin, AdIOptica GmbH**

### Increasing the Productivity of Femtosecond Laser Using a Spatial Light Modulator (M306)

**Petri Laakso, Raimo Penttilä, Ilkka Vanttaja, VTT; Martti Silvennoinen, Jarno Kaakkunen, Kimmo Pääsaari, Univ. of Eastern Finland**

### An Aspherical Reflecting Focusing Method for Direct Semiconductor Laser (M311)

**Xubao Wang, Qinggai Mi, Dongyu Liu, Institute of Laser Engineering, Beijing Univ. of Technology**

### Advances in Ultra Short Pulsed Parallel Processing Using a Spatial Light Modulator (M308)

**Stuart Edwardson, Zheng Kuang, Dun Liu, Walter Perrie, Geoff Dearden, Ken Watkins, Univ. of Liverpool**

### The Impact of Graphite Coating and Wavelength on Picosecond Laser Machining of Optical Glasses (M309)

**Krystian Włodarczyk, Frank Albri, Robert Maier, Duncan Hand, Heriot-Watt Univ.; Nick Weston, Renishaw PLC**

## Program Committee:

**Neil Ball, Directed Light Inc., San Jose, CA, USA**

**Masayuki Fujita, Institute for Laser Technology, Osaka, Japan**

**Jack Gabzdyl, SPI Lasers, Southampton, Great Britain**

**Sami Hendow, Consultant, Los Altos, CA, USA**

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**Yasuhiro Okamoto, Okayama Univ., Okayama, Japan**

**Alexander Olowinsky, Fraunhofer ILT, Aachen, Germany**

**Yasu Osako, ESI, Portland, OR, USA**

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**Sascha Weiler, TRUMPF Inc., Farmington, CT, USA**

**Bodo Wojakowski, Laser Zentrum Hannover e.V., Hannover, Germany**

**Xiaoyan Zeng, Huazhong Univ. of Science & Technology, Wuhan, People's Republic of China**

**LMF Session 4: Microwelding****September 25, 2012 • 1:30pm***Session Chair: Geoff Shannon, Miyachi Unitek, Monrovia, CA, USA***Welding Characteristics of Foturan Glass Using Ultrashort Laser Pulses - Invited Presentation (M401)***Isamu Miyamoto, Osaka Univ.; Yasuhiro Okamoto, Okayama Univ.; Kristian Cvecek, Michael Schmidt, Univ. Erlangen-Nuremberg; Henry Helvajian, The Aerospace Corporation***Novel Fusion Welding Technology of Si/Glass Using Ultrashort Laser Pulses with High Pulse Repetition Rates (M402)***Isamu Miyamoto, Osaka Univ.; Yasuhiro Okamoto, Okayama Univ.; Jarno Kangastupa, Tiina Amberla, Corelase Ltd.; Assi Hansen, Jorma Vihinen, Tampere Univ. of Technology***Quasi Continuous Wave (QCW) Long Pulse Fiber Lasers (M403)***Tony Houlty, IPG Photonics Corporation***Examinations on Laser-Welded Joints of Ultra-Thin Metallic Foils (M404)***Andreas Patschger, Univ. of Applied Sciences Jena***Model for Laser Spot Welding Stability and Analyses on Copper (M405)***Anas Moalem, Philipp Von Witzendorff, Uwe Stute, Ludger Overmeyer, Laser Zentrum Hannover e.V.***Micro-Laser-GMA Hybrid Welding - The Advancement from Macro to Micro Range (M406)***Stefan Jakobs, Michael Mavany, Uwe Reisgen, Welding and Joining Institute, RWTH-Aachen Univ.***LMF Session 5: Processing of Transparent and Brittle Materials****September 25, 2012 • 1:30pm***Session Chair: Yasu Osako, ESI, Portland, OR, USA***The Discussion About the Crack in the Glass Caused by Laser (M501)***Chao Huang, Jimin Chen, Jianwen Yuan, Beijing Univ. of Technology***Singulation of Sapphire Substrate with High Aspect Ratio Internal Modification by Sub-Nanosecond Pulsed Fiber Laser (M502)***Yasuhiro Okamoto, Kenta Takahashi, Akira Okada, Okayama Univ.***The Impact of Thermal Strain Rate on Laser Bonding of Polymer Films (M506)***Colin Dowding, Loughborough Univ.***Laser Transmission Welding with Part Adapted Temperature Fields (M507)***Martin Devrient, Thomas Frick, BLZ Bayerisches Laserzentrum GmbH; Verena Wippo, Peter Jaeschke, Heinz Haferkamp, LZH Laserzentrum Hannover e.V.; Michael Schmidt, LPT Lehrstuhl fuer Photonische Technologien Der Friedrich-Alexander Univ. Erlangen-Nuernberg***Diagnostic and Simulation of ps-Laser Glass Cutting - Invited Presentation (M504)***Urs Eppelt, Wolfgang Schulz, Claudia Hartmann, Fraunhofer ILT; Simone Russ, TRUMPF Laser GmbH+ Co. KG; Christof Siebert, TRUMPF Laser-und Systemtechnik GmbH***CO<sub>2</sub> Laser Free-Shape Cutting of Flexible Glass Substrates (M505)***Xinghua Li, Sean Garner, Corning Inc.***LMF Session 6: Thin Film Processing****September 26, 2012 • 8:30am***Session Chair: Sascha Weiler, TRUMPF Inc., Farmington, CT, USA***Influence of Nitrogen on Diamond Films Generated by Laser-CVD (M601)***Knut Partes, Michael Schwander, Frank Vollertsen, BIAS***Line Beam Laser Lift-Off Approach for Sapphire Removal (M602)***Ralph Delmdahl, Rainer Paetzel, Rolf Senczuk, Jan Brune, Coherent GmbH; Michael Kunzer, Ruediger Moser, Christian Gossler, Ulrich Schwarz, Fraunhofer IAF***Evaluation of Damaged Region at the Groove Edge of TCO Film in Pulsed Fiber Laser Processing (M603)***Yasuhiro Okamoto, Naoya Takahashi, Akira Okada, Okayama Univ.; Shin-Ichi Nakashiba, Tomokazu Sakagawa, Kataoka Corporation***Ultrafast Movies of Thin Film Ablation with Ultra-Short Laser Pulses (M604)***Matthias Domke, Stephan Rapp, Gerhard Heise, Heinz Huber, Munich Univ. of Applied Sciences***Mechanism of Selective Removal of Transparent Conductive Oxide Layers: Femtosecond- vs. Picosecond- Laser Pulse Ablation (M605)***Juerg Aus Der Au, Victor Matyitsky, High Q Laser GmbH; Heinz Huber, Lasercenter, Munich Univ. of Applied Science***LMF Session 7: Surface Modification I****September 26, 2012 • 8:30am***Session Chair: Jack Gabzdyl, SPI Lasers, Southampton, Great Britain***Texturing of 3D Curved Surfaces Using Picosecond Pulsed Lasers - Enabling New Applications of Functional Surfaces - Invited Presentation (M705)***Max Groenendijk, Lightmotif B.V.***Comparison Study of Sub Microstructure Generation on Metals Between Femtosecond Ti:Sa Laser and High Repetition Yb Doped Fiber Laser (M702)***Marc Faucon, John Lopez, Rainer Kling, ALPhANOV***Femtosecond Laser Ablation of Dentin (M703)***Rui Vilar, Instituto Superior Técnico***Wear Protection of Drilling Tools Using Laser Dispersing (M704)***Christian Noelke, Laser Zentrum Hannover e.V.***LMF Session 8: Lasers in Energy Generation and Storage****September 26, 2012 • 10:30am***Session Chair: Rainer Kling, ALPhANOV, Talence Cedex, France***Lasers in Thin Film Photovoltaic - Invited Presentation (M801)***Kerstin Kowalick, Ruhr-Univ. Bochum***Laser Scribing of ITO/ZNO Thin Films on Flexible PET Foil for Roll to Roll Production of Polymer Solar Cells (M802)***Susana Abreu Fernandes, Kerstin Kowalick, Ruhr-Univ. Bochum***Transmissive Optic System for Manipulation of Ignition Location in Laser Ignition for Gas Turbines (M803)***Jonathan Griffiths, Jonathan Lawrence, Univ. of Lincoln***Investigation of Different Laser Cutting Strategies for Sizing of Li-Ion Battery Electrodes (M804)***Rahul Patwa, Hans Herfurth, Stefan Heinemann, Fraunhofer USA, CLT; Jyoti Mazumder, Dongkyoung Lee, The Univ. of Michigan***Joining of Lithium-Ion Batteries Using Laser Beam Welding (M805)***Philipp Schmidt, Markus Schweier, Robert Wiedenmann, Michael F. Zaeh, Institute for Machine Tools and Industrial Management (IWB) of Technische Univ. München***LMF Session 9: Surface Modification II****September 26, 2012 • 10:30am***Session Chair: Veli Kujanpaa, VTT Technical Research Centre of Finland, Lappeenranta, Finland***Phase Change Writing in Sn-Doped Ge-Sb-Te Film with Ultraviolet Laser (M901)***Weiping Zhou, Furong Liu, Chao He, Jianjun Zhao, Jimin Chen, Beijing Univ. of Technology***Research Progress on Phase Change Materials for Optical Storage (M902)***JianJun Zhao, Furong Liu, Weiping Zhou, Beijing Univ. of Technology***Laser Precision Surface Sculpting of 2D Diffractive Optical Structures on Stainless Steels (M903)***Stephanie Giet, Andrew Dunn, Marcus Ardrion, Duncan Hand, Robert Maier, Heriot Watt Univ.; Nick Weston, Matthew Kidd, Renishaw PLC***Laser Surface Texturing of Bioactive Materials (M904)***Juan Pou, Ramon Soto, Rafael Comesana, Mohamed Boutinguiza, Jesus Del Val, Felix Quintero, Fernando Lusquinos, Univ. of Vigo; Antonio Riveiro, Centro Univ. de la Defensa*

**Pulsewidth Dependence of Laser Induced Periodic Surface Structures Using a Picosecond Fiber Laser (M905)**

Brian Baird, Summit Photonics; Tim Gerke, Fianium Inc.

**Improving the Wettability on ZnO and ZrO<sub>2</sub> Single Crystal Surfaces by Laser Irradiation (M906)**

Yijian Jiang, Beijing Univ. of Technology

**LMF Session 10: Modeling and Physical Interactions**

**September 26, 2012 • 3:00pm**

Session Chair: Yasuhiro Okamoto, Okayama Univ., Okayama, Japan

**Infrared-Visible Light Conversion Using DCM Dye Micrograins Embedded in a Resin Sheet and Application to an IR Sensor Card (M1001)**

Tadashi Kawazoe, Motoichi Ohtsu, Univ. of Tokyo; Tohru Fujita, Hiroyasu Fujiwara, Minoru Niigaki, Hamamatsu Photonics KK

**Femtosecond Laser Ablation of Metals at Different Fluences and the Role of Early Stage Plasma (M1002)**

Xin Zhao, Yung Shin, Purdue Univ.

**Characterisation of Interaction Phenomena in High Repetition Rate Femtosecond Laser Ablation of Metals (M1003)**

Joerg Schille, Lutz Schneider, Lars Hartwig, Robby Ebert, Horst Exner, Univ. of Applied Sciences Mittweida; Patricia Scully, Nicholas Goddard, The Univ. of Manchester

**From ps to fs: Dependence of the Material Removal Rate and the Surface Quality on the Pulse Duration for Metals, Semiconductors and Oxides (M1004)**

Beat Neuenschwander, Beat Jaeggi, Michelle Buechel, Marc Schmid, Urs Hunziker, Bern Univ. of Applied Sciences Engineering and Information Technology

**Non-Dimensional Evaluation of Nonlinear Absorptivity in Internal Modification of Glass Using USLP (M1005)**

Isamu Miyamoto, Osaka Univ.; Kristian Cvecek, Bayerisches Laserzentrum; Michael Schmidt, Univ. Erlangen-Nuremberg

**Effects of Polarization on Laser Diffusion and Materials Modification (M1006)**

Sen-Yong Chen, Aravinda Kar, The College of Optics and Photonics, Univ. of Central Florida; Raj Vaidyanathan, AMPAC, UCF

**LMF Session 11: Monitoring and Detection**

**September 26, 2012 • 3:00pm**

Session Chair: Andreas Wetzig, Fraunhofer IWS, Dresden, Germany

**Inline Coherent Imaging at Higher Powers - Invited Presentation (M1101)**

Paul J. L. Webster, Queen's Univ.

**Real Time Surface Tracking System in Laser Micromachining (M1102)**

Ville Hautala, Jorma Vihinen, Tampere Univ. of Technology; Antti Maattanen, Primoceler

**Analysis of Nanosecond Laser Ablation Rate of Metals with and without Phase Explosion in Air and Water (M1103)**

Yunfeng Cao, Xin Zhao, Yung Shin, Purdue Univ.

**Characterization of Shaped Nanosecond Laser Ablation Events Using High Speed Pulsed Digital Holography (M1104)**

Krste Pangovski, William O'Neill, Institute for Manufacturing, Univ. of Cambridge

**1.3µm-Band Si Photodetectors with Optical Gains Fabricated by Dressed Photon Assisted Annealing (M1105)**

Hajime Tanaka, Tadashi Kawazoe, Motoichi Ohtsu, The Univ. of Tokyo

**LMF Session 12: Microprocessing and Drilling**

**September 27, 2012 • 8:30am**

Session Chair: Kevin Hartke, Mound Laser & Photonics Center, Inc., Miamisburg, OH, USA

**Trend Analysis of Laser Micromachining - Invited Presentation (M1201)**

Wenwu Zhang, GE GRC

**Dual Beam Laser Grooving of CFRP by Pulsed Lasers (M1202)**

Masayuki Fujita, Toshihiro Somekawa, Institute for Laser Technology; Takumi Ozaki, Minoru Yoshida, Kinki Univ.; Noriaki Miyana, Institute of Laser Engineering, Osaka Univ.

**Potentials for Lasers in CFRP Production (M1203)**

Rainer Kling, Charly Lumena, John Lopez, ALPhANOV

**Heat Accumulation in Short-Pulse Laser Processing (M1204)**

Rudolf Weber, Andreas Michalowski, Anne Feuer, Peter Berger, Thomas Graf, IFSW, Univ. of Stuttgart

**Laser-Beam Helical Drilling of High Quality Micro Holes (M1205)**

Christian Fornaroli, Fraunhofer ILT

**Investigation of the Cutting Performance of Laser Dressed Metal Bonded Diamond Blades (M1206)**

Philipp von Witzendorff, Anas Moalem, Uwe Stute, Ludger Overmeyer, Laser Zentrum Hannover e.V.

**High Precision and High Throughput Surface Structuring by Synchronizing Mechanical Axes with an Ultra Short Pulsed Laser System in MOPA Arrangement (M1207)**

Guido Hennig, Guido Hennig, Daetwyler Graphics Ag; Urs Hunziker, Beat Jaeggi, Thomas Meier, Beat Neuenschwander, Markus Zimmermann, Bern Univ. of Applied Sciences Engineering and Information Technology

**Pulsed Laser Cutting of Bright Metals (M1208)**

Paul Harrison, SPI Lasers

**LMF Session 13: Advances in Laser Sources**

**September 27, 2012 • 8:30am**

Session Chair: Nam Seong Kim, EO Technics, Anyang, South Korea

**High Average Power Compact Ultrafast Fiber Amplifier (M1301)**

Franck Morin, Yoann Zaouter, Robert Braunschweig, Clemens Hoenninger, Eric Mottay, Amplitude Systemes

**Hundreds of Milliwatts Supercontinuum Generation in All-Fiber Laser (M1302)**

Chang Sun, Beijing Univ. of Technology

**Frequency Shifting of High Intensity Picosecond Lasers by Stimulated Raman Scattering (M1303)**

Xu Yang, Institute of Laser Engineering, Beijing Univ. of Technology

**2µm Tm-Doped Picosecond All-Fiber Laser with 7.8 W Average Output Power (M1304)**

Yi Cao, Jiang Liu, Jiang Liu, Qian Qiang, Pu Wang, Jia Xu, Beijing Univ. of Technology

**Pulse Energy Scaling of ps to ns Pulses in Highly Integrated Fiber Amplifiers for Micromachining (M1305)**

Hakan Sayinc, Jörg Neumann, Thomas Theeg, Dietmar Kracht, Laser Zentrum Hannover e.V.

**New Generation Q-Switched DPSS Nanosecond Green Laser for Efficient Micromachining Applications (M1306)**

Ashwini Tamhankar, Rajesh Patel, Spectra-Physics Lasers, Newport Corporation

**High Power 532 nm Square Beam Delivery (M1307)**

Andrew Chesworth, Lee Laser, Inc.

**The Research on the Micro Processing Used All-Solid-State Nanosecond UV Laser (M1308)**

Zhenxu Bai, Beijing Univ. of Technology

**High Average Power, High Energy Femtosecond Regenerative Amplifiers (M1309)**

Martin Delaigue, Robert Braunschweig, Clemens Hoenninger, Eric Mottay, Amplitude Systemes



# Nanomanufacturing Conference

Conference Co-Chairs:

**Yongfeng Lu, Univ. of Nebraska – Lincoln, Lincoln, Nebraska, USA**

**Xianfan Xu, Purdue Univ., West Lafayette, Indiana, USA**

The Nanomanufacturing Conference of ICALOE® presents nanomanufacturing papers relevant to laser technologies. Much progress has been achieved in laser direct writing, laser nanomachining and

nanofabrication using ultrafast lasers and laser-assisted growth of nanostructures. This conference will highlight research in emerging nanomanufacturing technologies in 3-D micro/nanofabrication, two-photon lithography, laser synthesis and diagnostics of carbon nanomaterial, epitaxial growth of graphene for optoelectronics, nanolithography, nanoscale thermal imaging, plasmonics, surface nanostructuring, laser sintering and laser-assisted growth and epitaxy. These studies encompass a variety of applications, including nanoelectronics, photonic crystals, optoelectronics, sensors and plasmonic devices.

## Nano Session 1: Laser Micro/Nano Processing

**September 24, 2012 • 3:20pm**

*Session Chair: Yongfeng Lu, Univ. of Nebraska-Lincoln, Lincoln, NE, USA*

**Femtosecond Laser Inscribed Fiber Devices and Their Sensing Applications - Invited Presentation (N101)**

*Qiyang Chen, Ping Lu, Liqiu Men, Memorial Univ. of Newfoundland*

**Opto-Hydrodynamic Processing of Materials Using Microdroplets - Invited Presentation (N102)**

*Dongsik Kim, POSTECH*

**Micromachining Through Silicon Substrates by Ultrafast Laser at 1552 nm (N103)**

*Yoshiro Ito, Yuichi Morita, Rie Tanabe, Department of Mechanical Engineering, Nagaoka Univ. of Technology; Hidemasa Sakurai, Kozo Tada, Citizen Finetech Miyota Co. Ltd.*

## Nano Session 2: Laser-Material Interactions at Nanoscales

**September 25, 2012 • 8:30am**

*Session Co-Chairs: Xinwei Wang, Iowa State Univ., Ames, IA, USA; Xianfan Xu, Purdue Univ., West Lafayette, IN, USA*

**Nonequilibrium Laser Synthesis and Real-Time Diagnostics of Carbon Nanomaterials - Invited Presentation (N201)**

*David Geohegan, Alex Puretzky, Murari Regmi, Chris Rouleau, Gyula Eres, Karren More, Oak Ridge National Laboratory; Gerd Duscher, Univ. of Tennessee, Dept. of Materials Science and Engineering*

**Enhanced Mobility of Surface Molecular Species by Laser Ultrasonic Excitation - Invited Presentation (N202)**

*Henry Helvajian, The Aerospace Corporation*

**Efficient Laser Coupling into Plasmonic Nanoantenna Arrays for Fabrication and Characterization of Sensitive IR Bolometers (N203)**

*M. Mahjouri-Samani, W. Xiong, X.N. He, Y.S. Zhou, P. Hilger, Yongfeng Lu, Univ. of Nebraska-Lincoln*

**Femtosecond Laser Welded Plasmonic Thin Films for Enhanced Performance of Si Solar Cells (N204)**

*Anming Hu, Univ. of Waterloo*

**Epitaxial Graphene for Photonics and Optoelectronics – Invited Presentation (N205)**

*Ji Wei, National Univ. of Singapore*

**Nanotemplate-Assisted Fabrication of Nanoneedle/Nanoprotrusion Array and Nano-Periodic Surface Ripples - Invited Presentation (N206)**

*Mitsuhiro Terakawa, Go Obara, Yuto Tanaka, Hisashi Shimizu, Minoru Obara, School of Integrated Design Engineering, Keio Univ.; Eric Mazur, Department of Physics, Harvard Univ.*

**Laser Direct Written Silicon Nanowires and Graphene for Chemical Sensing Applications (N207)**

*Woongsik Nam, James Mitchell, Dapeng Wei, Xianfan Xu, Purdue Univ.*

## Nano Session 3: Thermal Characterization and Processing at Micro/Nanoscales

**September 26, 2012 • 8:30am**

*Session Chair: David Geohegan, Oak Ridge National Laboratory, Oak Ridge, TN, USA*

**Far-Field Nanoscale Thermal and Structure Imaging - Invited Presentation (N301)**

*Xinwei Wang, Iowa State Univ.*

**Role of Metal/Matrix Interfaces in the Thermal Management of Metal-Carbon Composites - Invited Presentation (N302)**

*Namas Chandra, Yongfeng Lu, Dept. of Electrical Engineering, Univ. of Nebraska-Lincoln; Thomas Guillemet, Jean-Marc Heintz, Jean-Francois Silvain, Institute of Condensed Matter Chemistry of Bordeaux, Univ. Bordeaux*

**Evaluation of Thermal Resistance at Silicon/Diamond Interfaces Through Infrared Photothermal Radiometry (N303)**

*Jean-Luc Battaglia, Andrzej Kusiak, Andrea Cappella, Institut de Mecanique et Ingenierie, Dept. Trefle; Yongfeng Lu, Dept. of Electrical Engineering, Univ. of Nebraska-Lincoln; Namas Chandra, Jean-Marc Heintz, Jean-Francois Silvain, Institute of Condensed Matter Chemistry of Bordeaux; Thomas Guillemet, Univ. of Nebraska – Lincoln, Institute of Condensed Matter Chemistry of Bordeaux*

**Fabrication of Micro-Nano Hierarchical Cu Structures on Engineering Substrate by Hybrid Laser Approach and their Application to Photodegradation of Methyl Orange Under Visible Light (N304)**

*Minlin Zhong, Changsheng Dong, Ting Huang, Tsinghua Univ.*

## Nano Session 4: Laser Nanolithography and Nanostructuring

**September 26, 2012 • 10:30am**

*Session Chair: Henry Helvajian, The Aerospace Corporation, Los Angeles, CA, USA*

**Plasmon-Assisted Nanolithography Exposed by Femtosecond Laser Beam Through Gold Nanostructured Photomasks - Invited Presentation (N401)**

*Kosei Ueno, Hokkaido Univ.*

**The Black and Colored Metals and Applications - Invited Presentation (N402)**

*Chunlei Guo, Univ. of Rochester*

**Multi-Material Projection Micro-Stereolithography and its Applications (N403)**

*Howon Lee, Howon Lee, Chunguang Xia, Univ. of Illinois at Urbana-Champaign;*

*Nicholas Fang, MIT*

**Three-Dimensional Micro/Nano-Fabrication by Integration of Additive and Subtractive Femtosecond-Laser Direct Writing Processes (N404)**

*W. Xiong, Y.S. Zhou, X.N. He, Y. Gao, M. Mahjouri-Samani, Y.F. Lu, Univ. of Nebraska-Lincoln; T. Baldacchini, Newport Corporation*

**Beam Shaping Optics to Improve Holographic and Interferometric Nanomanufacturing Techniques (N405)**

*Alexander Laskin, Vadim Laskin, AdlOptica GmbH*

## Nano Session 5: Laser Applications in Flexible Electronics

**September 27, 2012 • 8:30am**

*Session Chair: Dongsik Kim, POSTECH, Pohang, South Korea*

**Laser-Assisted Dry Transfer of Vertically Aligned Carbon Nanotube Array on Flexible Polymer Substrates (N501)**

*Daeho Lee, Jung Bin In, Costas Grigoropoulos, UC Berkeley*

**An Experimental Investigation into the Laser Sintering Process of Cu Nanoparticle Based Ink on Polymer Substrates for Printed Electronics (N502)**

*Juan Carlos Hernandez-Castaneda, Gary Ka Lai Ng, Lok Boon Keng, Singapore Institute of Manufacturing Technology*

**Nano-Needle Fabrication Based on Optical Vortex Laser Ablation (N503)**

*Kohei Toyoda, Katsuhiko Miyamoto, Nobuyuki Aoki, Takashige Omatsu, Chiba Univ.*

## Program Committee:

**Craig Arnold**, Princeton Univ., Princeton, NJ, USA

**Tommaso Baldacchini**, Newport Corporation, Irvine, CA, USA

**Stephan Barcikowski**, Univ. of Duisburg-Essen and Center for Nanointegration Duisburg-Essen (CeNIDE), Essen, Germany

**Kevin Chen**, Beijing Golden Way Scientific Co. Ltd., Beijing, People's Republic of China

**Shaochen Chen**, Univ. of Texas at Austin, Austin, TX, USA

**Haris Domanidis**, Univ. of Cyprus, Nicosia, Cyprus

**Nick Fang**, MIT, Cambridge, MA, USA

**Costas Grigoropoulos**, Univ. of California - Berkeley, Berkeley, CA, USA

**Changzhi Gu**, Institute of Physics, Chinese Academy of Sciences, Beijing, People's Republic of China

**Peter Herman**, Univ. of Toronto, Toronto, Canada

**Yoshiro Ito**, Nagaoka Univ. of Technology, Nagaoka, Niigata, Japan

**Sungho Jeong**, Gwangju Institute of Science and Technology, South Korea

**Lan Jiang**, Beijing Institute of Technology, Beijing, People's Republic of China

**Yuankun Lin**, Univ. of Texas-Pan American, Edinburg, TX, USA

**Etsuji Ohmura**, Osaka Univ., Toyonaka, Osaka, Japan

**Alberto Pique**, Naval Research Laboratory, Washington, DC, USA

**Genot Pomrenke**, AFOSR, London, Great Britain

**Xinwei Wang**, Iowa State Univ., Ames, IA, USA

**Yunshen Zhou**, Univ. of Nebraska – Lincoln, Lincoln, NE, USA

## Poster Presentation Gallery

Tuesday, September 25 & Wednesday, September 26

The Poster Presentation Gallery will be featured on Tuesday and Wednesday of the conference. Join presenters Wednesday morning for breakfast and sharing of ideas. Poster Presenters will be by their posters on Wednesday morning from 7:45am – 8:30am to answer questions. Poster presenters who submit a manuscript will be included in the ICALEO Proceedings.



### TEA CO<sub>2</sub> Laser Machining of Carbon Fiber-Reinforced Polymer Composites (P101)

Adel Salama, Paul Mativenga, Lin Li, The Univ. of Manchester

### Study of the Behaviour of Carbon-Fiber-Reinforced Polymer Composite Using Shock Produced by Laser (P102)

Laurent Berthe, CNRS/Laboratoire Procédés et Ingénierie en Matériaux et Mécanique

### Independent Focus Position and Focus Diameter Control - An Optimized Laser Cutting Head for High Brightness Solid State Lasers (P103)

Björn Wedel, Hagen Zimer, HIGHYAG Lasertechnologie GmbH

### Observations of Delamination Induced by Laser Drilling on a Cobalt Base Superalloy (P104)

Girardot Jeremie, Schneider Matthieu, Berthe Laurent, Favier Veronique, PIMM Laboratory, Arts et Métiers ParisTech

### Diode-Pumped Nanosecond Nd:YAG Laser Micromachining of Ti-3Al-2.5V Tubes for Fatigue Life Study (P105)

Yaomin Lin, Alfred Mann Foundation for Scientific Research; Mool Gupta, Department of Electrical and Computer Engineering, Univ. of Virginia

### Investigation of the Interactions Between Laser-Sustained Plasma and a Substrate Without Direct Laser Irradiation (P106)

Amber Black, Judith Todd, The Penn State Univ.; Stephen Copley, ARL, The Penn State Univ.

### Design for Laser Welding (P107)

David Havrilla, TRUMPF Inc.

### Maximizing Laser Utilization and Productivity - On-The-Fly Robot Remote Laser Welding in the 3<sup>rd</sup> Dimension (P108)

Björn Wedel, Hagen Zimer, HIGHYAG Lasertechnologie GmbH

### Position Welding of 960 MPa Ultra High-Strength Steel (P110)

Jukka Siltanen, Rautaruukki Oyj

### Evaluation of Laser Welding Quality Based on a Plasma Spectroscopy in a Continuous Steel Process (P111)

Jun Choi, POSCO

### Pulsed Laser Weldability of Hastelloy C-276: Corrosion Resistant Property (P113)

Dongjiang Wu, Guangyi Ma, Shibo Liu, Mengxue Wu, Dalian Univ. of Technology

### Welding of Aluminum Alloy 6061 to Zinc Coated Steels by Cold Metal Transfer (P114)

Shanglu Yang, General Motor China Science Lab

### Study on Microstructures and Properties of Laser Beam Welded 2024 Aluminum Alloy T-Joint (P115)

Enguang He, Beijing Aeronautical Manufacturing Technology Research Institute

### Laser Beam Welding of Al-Li Alloys for Aerospace Application (P116)

Xinyi Zhang, Rongshi Xiao, Beijing Univ. of Technology

### Yb:YAG Laser Welding for CaO Added AZ31 Mg Alloy (P117)

Cheolhee Kim, Minjung Kang, KITECH

### Effect of Laser Shocking on Intergranular Corrosion Resistance of 304 Type Austenite Stainless Steel (P119)

Zhenyu Gu, Sen Yang, Nanjing Univ. of Science and Technology

### Effects of Laser Peening Parameters on Plastic Deformation of SUS316L (P120)

Kohei Mizuta, Kinki Univ.

### Characterization of TC17 Titanium Alloy Treated by Square-Spot Laser Shock Peening (P121)

Cao Ziwen, BAMTRI

### Microstructural Evolution at the Overlap Zones of X12Cr Martensitic Stainless Laser Alloyed with TiC (P122)

Isaac Adebisi, Abimbola Patricia Popoola, Tshwane Univ. of Technology; Sisa Pityana, Centre for Scientific and Industrial Research

### Dual System of Laser Cladding and Heat Treatment System for Low Friction and Good Wear Resistivity of Mechanical Bearing Surface (P123)

Sun-Hong Park, Byeong Geun Seong, RIST

### Laser Cladding with Coaxial Wire Feeding (P124)

Henri Pajukoski, Jonne Näkki, Petri Vuoristo, Jari Tuominen, Tampere Univ. of Technology, Department of Materials Science; Sebastian Thieme, Steffen Nowotny, Fraunhofer IWS, Material and Beam Technology

### Corrosion Resistant Laser Coatings for Hydraulic Piston Rods (P126)

Jari Tuominen, Jonne Näkki, Petri Vuoristo, Tampere Univ. of Technology, Department of Materials Science; Juha Miettinen, Tampere Univ. of Technology, Department of Mechanics and Design; Juha Junkala, Tuomo Peltola, Technology Centre Ketek Ltd.

### Thermal and Mechanical Modeling of Single Metallic Powder Layer for Laser Micro Sintering (P128)

Jie Yin, Haihong Zhu, Linda Ke, Chongwen He, Panpan Hu, Hong Chen, Duluo Zuo, Huazhong Univ. of Science and Technology, College of Optoelectronic Science and Engineering

### Fabrication of Three-Dimensional Nickel Parts Using Laser Micro Sintering (P129)

Linda Ke, Haizhong Zhu, Jie Yin, Chongwen He, Panpan Hu, Hong Chen, Xinbing Wang, Huazhong Univ. of Science and Technology

### Laser-Assisted Manufacturing of Porous Metallic Structures (P130)

Jesus Del Val, Rafael Comesana, Fernando Lusquinos, Mohamed Boutinguiza, Felix Quintero, Juan Pou, Univ. of Vigo; Antonio Riveiro, Centro Univ. de la Defensa

### Analysis of Process Parameters on Melt Pool Stability in Powder Bed Laser Melting (P131)

Pascal Aubry, Arts et Métiers ParisTech

### Capability of Hot Isostatic Pressing on Crack Healing and Microstructure Modification on Rene'80 Prepared by Direct Laser Deposition (P132)

Yanmin Li, Henry Peng, Zhiwei Wu, General Electric (China) Research & Development Center Co. Ltd.

### Analysis and Simulation of the Effects of Clad Strategy on Layer Microstructure and Properties (P133)

Mushtaq Khan, Michael Vogel, Juansethi Ibarra-Medina, Andrew J Pinkerton, Manufacturing and Management Group, School of Mechanical, Aerospace and Civil Engineering, The Univ. of Manchester; Narcisse N'Dri, Mustafa Megahed, ESI GmbH

### Laser Powder Deposition of AlMgB14/TiB2 (BAM) Ultra-Hard Coatings on Steel and Titanium Substrates (P134)

Michael Carter, South Dakota School of Mines & Technology; James Sears, Quad City Manufacturing Laboratory / South Dakota School of Mines & Technology

### Incorporation of CNT-Yarns into Metals by Laser Melting of Powder (P135)

Alexander Kaplan, Alexander Soldatov, Luleå Univ. of Technology; Peter Norman, The Swedish Welding Commission; John Powell, Laser Expertise Ltd.; Shaoli Fang, Ray Baughman, The Univ. of Texas at Dallas

### Fieldbus Interfaces and Robust Design Laser Beam Monitoring Meet the Requirements for Applications in Production (P138)

Volker Brandl, Otto Märten, Kramer Reinhard, Harald Schwede, Stefan Wolf, PRIMES GmbH

### A New Method of Calculating Diode Laser Beam Quality for Fiber Coupling (P140)

Jing Gao, Beijing Univ. of Technology

### Fiber Amplified Diode Lasers with Programmable Pulse Shapes as a Versatile Light Source for Micromachining (P141)

Rainer Erdmann, Gerald Kell, Dietmar Klemme, Kristian Lauritsen, Thomas Schoenau, Picoquant GmbH

### 3W All-Fiber Super-Continuum Generation (P142)

Yu Feng, Beijing Univ. of Technology

### An Experimental Study of Laser Deep Machining (P143)

Emilie Le Guen, Institute of Condensed Matter Chemistry of Bordeaux

### Numerical Studies of Laser Cutting of an Anode for Lithium-Ion Batteries (P144)

Dongkyoung Lee, The Univ. of Michigan

## Micro Structuring of Steel Using Ultra Short Laser Pulses (P145)

Peter Lickschat, Joerg Schille, Robby Ebert, Horst Exner, Steffen Weissmantel,  
Univ. of Applied Sciences Mittweida

## Influence of Surrounding Gas Type and Pressure Condition on Micro-Drilling Characteristics of Silicon Carbide by Harmonics of Nd:YAG Laser (P146)

Yasuhiro Okamoto, Shin Urushibata, Akira Okada, Okayama Univ.;  
Shin-Ichi Nakashiba, Tomokazu Sakagawa, Kataoka Corporation

## Laser Micromachining of Si<sub>3</sub>N<sub>4</sub> Ceramics (P147)

Markus Höfer, Lothar Schäfer, IST; Sisa Pityana, CSIR - National Laser Centre;  
Lerato Tshabalala, Tshwane Univ. of Technology

## High Quality and High Speed Cutting of Al<sub>2</sub>O<sub>3</sub> Substrate with Single Mode Fiber Laser (P148)

Toshiaki Sakai, Akira Fujisaki, Kousuke Kashiwagi, Takashi Kayahara,  
Takashi Shigematsu, Furukawa Electric Company, Ltd.

## Application of LBM Technology for Precise Sapphire Hip Implant Manufacturing (P149)

Dominik Wyszynski, Jozef Gawlik, Cracow Univ. of Technology

## Ultrashort Pulse Laser Dicing Process of Sapphire Wafer

### Using a Multi-Beam (P150)

Yongkwon Cho, Jiyeon Choi, Sangkyu Choi, Dongsig Shin, Jeong Suh,  
Korea Institute of Machinery and Materials

## Laser Precision Micromachining and Quality Evaluation of Tempered Oxide Glasses (P151)

Jiyeon Choi, Hyonkee Sohn, Jeong Suh, Korea Institute of Machinery  
and Materials

## Suitable Processing Conditions Determined from the Standpoint of Residual Strain in Laser Scribing of Glass (P152)

Masanao Murakami, Seiji Shimizu, Mitsuboshi Diamond Industrial Co., Ltd.;  
Etsuji Ohmura, Keisuke Yahata, Osaka Univ.

## Comparison of Laser Glass Cutting Processes Using ps and fs Lasers (P153)

Byoungcheol Kim, Hyeonuk Kim, Nam Seong Kim, Cheonya Seong, EO Technics

## Nanosecond UV Laser Patterning of a Buildup Film with SiO<sub>2</sub> Fillers for Embedded Circuits (P154)

Hyonkee Sohn, Korea Institute of Machinery and Materials

## Optimizing Ultrashort Laser Pulses for High-Precision and High-Performance Micromachining Process (P155)

Hoon Jeong, Korea Institute of Industrial Tech; Dongjoo Lee, Kyunghee Park, KITECH

## Ultrafast Laser Delineation of Indium Tin Oxide Films for Photovoltaic Devices (P156)

Liqiu Men, Qiyang Chen, Memorial Univ. of Newfoundland

## Thin-Film Laser Scribing Processes Using ns, ps, and fs Pulses in CIGS Solar Cell Fabrication (P157)

Byoungcheol Kim, Nam Seong Kim, Hong Lee, Hwangjin Lee, EO Technics

## Selective Structuring of a Platinum/Tantalum Pentoxide Thin-Film Layer System by Induced Laser Ablation Investigated with Pump-Probe Microscopy (P158)

Janosch Rosenberger, Matthias Domke, Gerhard Heise, Heinz Huber, Munich Univ.  
of Applied Sciences

## Femtosecond Laser Microfabricated Optofluidic Devices and Underlying Laminar Flow (P159)

Daiying Zhang, Liqiu Men, Qiyang Chen, Memorial Univ. of Newfoundland

## 3D Laser Printing for Manufacturing Micro Structure of Tungsten Based Material (P160)

Rui Guo, GE Global Research Shanghai; Yanmin Li, Minghu Guo, Henry Peng,  
Wen Tan, Ge (China) Research & Development Center Co. Ltd.; Zemin Wang,  
Xiaoyan Zeng, Huazhong Univ. of Science & Technology

## A Thermal Investigation of Conductive Silver Ink Track Cured on Flexible Substrate by Repeating Irradiations of Nd:YAG Laser at the Wavelength at 532 nm (P161)

Liwei Fu, Eamonn Fearon, Walter Perrie, Geoff Dearden, Ken Watkins, Shuo Shang,  
Univ. of Liverpool

## Variation of Photocatalytic Activity in Titanium Dioxide Film Modified by Femtosecond Laser Irradiation (P162)

Naoto Horiguchi, Togo Shinonaga, Graduate School of Engineering, Osaka Univ.;  
Nobuyuki Abe, Joining and Welding Research Institute, Osaka Univ.; Masahiro  
Tsukamoto, Joining and Welding Research Institute, Osaka Univ.; Minoru  
Yoshida, School of Science and Engineering, Kinki Univ.; Masanari Takahashi,  
Osaka Municipal Technical Research Institute; Masayuki Fujita, Institute for Laser  
Technology, Osaka Univ.

## Matrix Independent Carbonization for the Laser Marking of Plastics (P165)

Matthew Gailey, EMD Chemicals, Inc.

## Correction for Point Cloud Acquired by Unstable Scanner (P166)

Jianfeng Ao, Kan Wu, Ming Zhou, China Univ. of Mining and Technology

## Mechanism of Micromachining of Semiconductor Silicon by Nano Short Pulses of Multi Wavelength Nd:YVO<sub>4</sub> Laser (P167)

Shiva Gadag, RCAM Southern Methodist Univ.

## Laser Welding of Seal Tubes for the Instrumented Fuel Irradiation Test (P168)

Soo-Sung Kim, Jon-Man Park, Don-Bae Lee, Yoon-Sang Lee, Korea Atomic Energy  
Research Institute

## Study on Ultrafast Imaging of the Silicon Surface Ablated by a Single Nanosecond Laser Pulse (P169)

Peng Gu, Song Haiying, Ge Qini, Liu Shibing, Liu Song, Dong Xiangming,  
Beijing Univ. of Technology

## Research on Improving of Cut Surface Quality of Laser-Cut Fine Ceramics (P170)

Lingfei Ji, Yijian Jiang, Yinzhou Yan, Yong Bao, Xiaochuan Chen, Beijing Univ.  
of Technology

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## Student Paper Award Contest

Announcing the 14<sup>th</sup> Annual ICALOE® Student Paper Award! LIA appreciates the importance of student contributions to ICALOE by offering the opportunity to have their work recognized with this award. Students with accepted papers will be judged by an international panel on the following criteria: Originality of Topic/Material presented, Scientific and Technical Merit and Presentation Quality. Professors do not judge their own student's papers. Prize winners will be notified after the conclusion of ICALOE and will be announced through an article in the LIA TODAY newsletter featuring conference highlights.

Cash awards will be presented to 1<sup>st</sup>, 2<sup>nd</sup>, 3<sup>rd</sup> place winners. Winning papers may be submitted to LIA's *Journal of Laser Applications*® for publication (papers will go through the peer review process).



## Business Forum & Panel Discussion

Chair: Ken Dzurko, SPI Lasers, Santa Clara, CA, USA

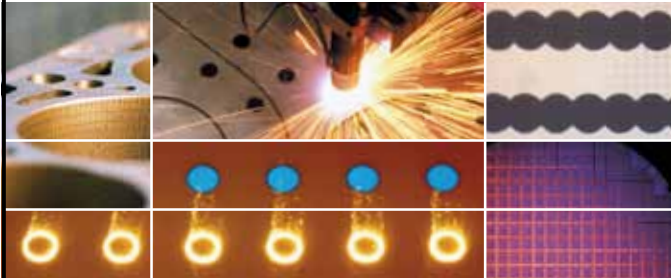
Monday, September 24 • 1:30pm

### Increasing the Role of Lasers in a Non-Laser World

The forum explores growing the serviceable available market (SAM) for industrial lasers by addressing the barriers perceived by traditionally non-laser manufacturing approaches. Success in accelerating the penetration of laser manufacturing technology relies on expanded awareness and acceptance. Considerations include:

- Beyond Star Wars – Perception of lasers needs to advance beyond the exotic to be accepted as a mainstream manufacturing tool. Safety and infrastructure needs, when examined closely, are no worse than traditional manufacturing methods.
- Capability – Laser applications demonstrate compelling capabilities to improve manufacturing precision, quality, yield and throughput.
- Cost triggers – When do laser beams become more cost effective than razor blade, glue and punch presses?

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(Courtesy of Chutian)



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- Easy integration in existing equipment

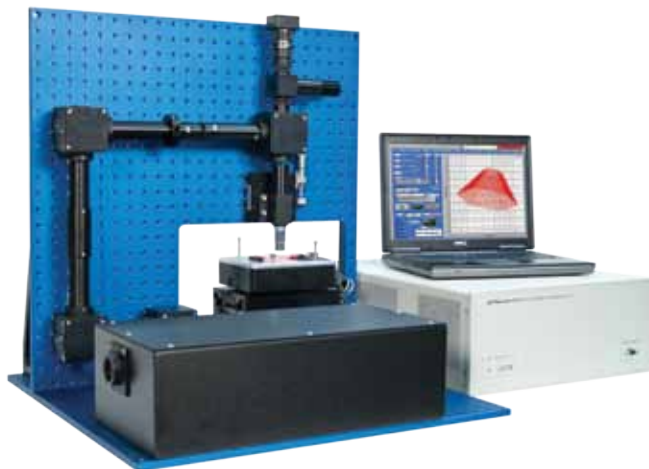
### Applications:

- Micromachining
- Scribing
- Welding
- Marking and Engraving
- Ablation, Cladding
- Annealing, Hardening
- Pumping, High Power and Short-Pulse Lasers
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## Laser Solutions Short Courses

Short Courses Chair: **Silke Pflueger, ULO Optics Inc., Los Gatos, CA, USA**

ICALEO's short courses session offers the opportunity to learn something new or brush up on existing skills. The first course discusses beam characterization, essential for everybody working with lasers. Heat treatment has been around for decades, but new lasers and sensors have made it a very competitive industrial process. Marking and engraving are standard technologies, but do you really understand them? Hybrid welding and micromachining are hot topics everybody talks about - learn more about them in the afternoon courses. The day also includes an exciting talk on how to turn your invention into a company!

### Course 1: Beam Diagnostics - Measurement Techniques and Applications

**Sunday, September 23 • 9:00am**

Volker Brandl, PRIMES GmbH, Pfungstadt, Germany

Participants will learn about the physical principles behind the instruments that measure laser properties. After a brief introduction to the parameters that describe a laser, we will discuss detection methods and try to find links between different application situations and the properties of the different detection techniques. Examples will be presented that show the links between alterations seen in the measurement data and the kind of error that occurred in the laser, beam path or focusing optics. Applications and future developments of laser beam analysis are outlined.

**The objectives for this course are:**

- 1) Quality assurance at laser systems.
- 2) Beam parameters – theory and practical measurements.
- 3) Detection techniques – physical principles behind beam analysis.
- 4) The impact of optical element failure on measurement data.
- 5) Industrial applications and integration of beam analysis.

**Course level:** Beginner to Intermediate

### Course 2: Laser Heat Treatment with Latest System Components

**Sunday, September 23 • 10:15am**

Steffen Bonss, Fraunhofer IWS, Dresden, Germany

Laser beam heat treatment has been established during the last years as a complementary technology for local hardening treatment tasks at tool manufacturing, automotive industry and many others. New high power diode lasers and a lot of process supporting systems, that have been developed in recent years, are responsible for the increase of industrial laser hardening applications. The short course starts with information about the basics of laser heat treatment. Thereafter, a review about suitable lasers and recommended systems for reliable and well adapted laser heat treatment processes is given. Examples of the last ten years transfer of laser beam hardening into industry are presented and discussed.

**The objectives for this course are:**

- 1) Laser heat treatment.
- 2) High power diode laser application.
- 3) Process monitoring and control.
- 4) Application examples from industry.

**Course level:** Beginner to Intermediate

### Course 3: Understanding Laser Marking, Engraving and Annealing and Current Trends

**Sunday, September 23 • 11:15am**

Jeff Thorsen, Telesis Technologies, Fremont, CA, USA

Today's micro material processing consists of many applications such as laser marking, laser annealing and laser engraving, yet many end users interchange these terms. Our short course will help define what each is, as well as educate the audience about the best means to mark, engrave and anneal using conventional mechanical pinstamp and industrial lasers. It is very common to hear technology people in a discussion throw around terms like marking, engraving and annealing. This course will provide the audience with a firm understanding of what these are and the methods and technologies to perform each.

**The objectives for this course are:**

- 1) Define what laser marking, engraving and annealing are.
- 2) Understand what technologies are available, such as fiber, solid state and gas lasers.
- 3) Understand what alternative technologies are available for marking and engraving such as pin stamp.

**Course level:** Beginner to Intermediate

### Course 4: Entrepreneurial Engineering

**Sunday, September 23 • 12:45pm**

Larry Marshall, Southern Cross Ventures, Palo Alto, CA, USA

Learn how to turn your invention into a company - learn how a fellow laser engineer founded 5 1/2 successful companies and delivered 2 successful IPOs.

**The objectives for this course are:**

- 1) Reverse how you think about technology and markets.
- 2) How to build and manage the right team for success.
- 3) How to pitch your idea to investors and secure capital.
- 4) How to create your business plan and pivot when necessary.
- 5) How and when to exit your company.

**Course level:** Beginner to Intermediate

### Course 5: Introduction to Laser Material Interactions and Micromachining with Pulsed Lasers

**Sunday, September 23 • 1:55pm**

Sami Hendow, Consultant, Los Altos, CA, USA

Sascha Weiler, TRUMPF Inc., Farmington, CT, USA

Participants will learn about the various regimes of laser-material interactions using pulsed lasers from microsecond to ultrashort pulse durations. We will discuss the various processes that are associated with energy exchange and their contribution to material processing. We will then cover the effects of changing peak power, pulse energy and pulse width, using nsec, psec and fsec pulses. We will also contrast the observed effects between these regimes on metal, silicon and ceramic materials, as well as other side effects such as oxide formation due to surface heating.

**The objectives for this course are:**

- 1) Basic understanding of the principles involved in laser-material interactions when pulsed lasers are used.
- 2) Recognize the various processes involved when a pulse is absorbed and ablation commences and their effects on material removal and HAZ.
- 3) Understand the effects of changing pulse peak power and pulse energy on material processing.
- 4) Recognize the impact of shortening pulse width on material processing.
- 5) Cover machining examples using nsec, psec and fsec lasers.

**Course level:** Beginner to Intermediate

### Course 6: Review of Hybrid Laser Arc Welding

**Sunday, September 23 • 2:55pm**

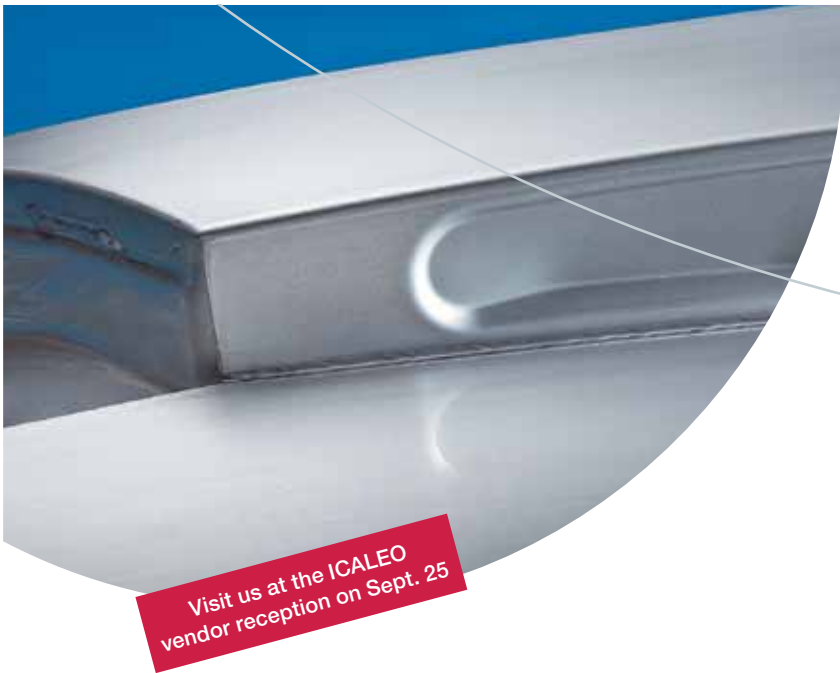
Brian Victor, Laserline, Inc., Santa Clara, CA, USA

This course provides an introduction to Hybrid Laser Arc Welding (HLAW), the combination of a laser and arc process in the same weld pool. This short course will review the fundamentals of each welding process, how to choose laser and arc equipment, typical process parameters and examples, typical defects, as well as the synergic benefits for multiple alloy systems: aluminum, steel/stainless and titanium.

**The objectives for this course are:**

- 1) Review the basics of each welding process.
- 2) Select the right equipment.
- 3) Determine starting parameters.
- 4) Learn how to troubleshoot common defects.

**Course level:** Beginner to Intermediate



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# Laser Industry Vendor Reception & Tabletop Display

Tuesday, September 25 • 4:00pm

## Sharing Ideas. Discovering Solutions.

As the world's premier conference on laser materials interaction, ICALEO® attracts over 200 companies and organizations from more than 30 countries. The Laser Industry Vendor Program gives vendors and conference attendees the opportunity to discuss equipment and applications in a relaxed setting. After completion of the technical sessions, enjoy drinks and hors d'oeuvres while sharing product ideas with your colleagues and suppliers! This is the only scheduled event for the evening, allowing participants access to the full attention of attendees. For information about participating as an ICALEO Sponsor or Vendor, please contact Jim Naugle at [jnaugle@lia.org](mailto:jnaugle@lia.org).

### **Sponsors and Vendors registered as of May 21<sup>st</sup>:**

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Laser Institute of America (LIA), founded in 1968, is the international society dedicated to fostering lasers, laser applications and laser safety worldwide. LIA has grown to represent hundreds of corporate and thousands of individual members in the laser industry.

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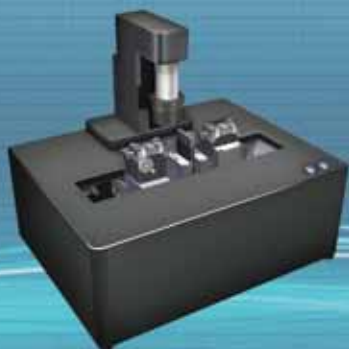
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# Conference Registration

Registration can be completed online or by downloading a PDF registration form from [www.icaleo.org](http://www.icaleo.org).

**Full conference registration** includes admission to all technical sessions, the Plenary Sessions, Laser Solutions Short Courses, Receptions (Welcome Celebration, President's Reception and Vendor Reception), Awards Luncheon and a technical digest.

**Student registration** includes admission to all technical sessions, the Plenary Sessions, Laser Solutions Short Courses, Receptions (Welcome Celebration, President's Reception and Vendor Reception), Awards Luncheon and a technical digest. A valid student ID is required to process registration. Student registration will not be accepted on-site; students must be pre-registered by August 31.

**One-day registration** includes admission to technical sessions, Laser Solutions Short Courses and receptions on that day only and a technical digest.

**Guests** may attend the Awards Luncheon and all receptions by purchasing tickets. Please pre-register your guest so we may prepare a nametag. **Non-industry guests only.**

Early Bird registrants must be paid in full by August 2. Visa, MasterCard and American Express will be accepted. You may send a check (US funds only, drawn on a US bank) payable to Laser Institute of America. Purchase orders must be paid in full by August 2 to qualify for discount. **Bank transfers must include a \$30 wire transfer fee.**

## On-site Registration Times

Sunday, September 23	8:00am – 4:00pm
Monday, September 24	7:00am – 5:00pm
Tuesday, September 25	7:30am – 4:00pm
Wednesday, September 26	7:30am – 5:00pm
Thursday, September 27	7:30am – 12:00pm

## Hotel Accommodations

### Anaheim Marriott® Hotel

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**Hotel Reservation Deadline is Thursday, August 30, 2012**

## Proceedings

CD-Rom Proceedings will be available on-site (they will not be shipped to you). It includes all submitted papers from ICALEO (Plenary, Laser Materials Processing, Laser Microprocessing, Nanomanufacturing and Poster Manuscripts).

### Payment received by August 2

\$145\*.....Member

\$170\*.....Non-Member

### Payment received after August 2

\$155\*.....Member

\$180\*.....Non-Member

\*Please note: 7.75% Sales Tax and Local Tax will be added to the CD-Rom proceedings in accordance with local tax laws.

## Substitutions and Cancellations

We understand that circumstances may occur to prevent you from attending the conference. If you find that you are unable to attend ICALEO®, you have several options:

1. **Send a substitute.** Substitutions can be made at any time – even on-site at the conference. (Please have the substitute bring your letter of confirmation to the registration desk)
2. **Refund of monies.** Requests for refunds must be made in writing and received on or before **August 2**.

**There is a \$75 processing fee** applied to all refunds. All refunds will be processed after the conference. No refund requests will be accepted after August 2. Guest Tickets, Proceedings & LIA Membership Dues are all non-refundable.

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## Special Needs

If you have any special needs that we can address to make your participation more enjoyable, please contact LIA by phone: +1.407.380.1553, Fax: +1.407.380.5588 or email: [icaleo@lia.org](mailto:icaleo@lia.org).

## Transportation

### Shuttle Service

Prime Time Shuttle provides shuttle service to and from the Anaheim Marriott Hotel. Make your reservations and print a coupon to save \$4 off your round trip transportation by visiting [www.lia.org/conferences/icaleo/transportation](http://www.lia.org/conferences/icaleo/transportation) or call +1.800.733.8267, press 1 for reservations and mention profile ID 398007.

## FEES

### Full Conference Registration

#### Early Bird (payment received by August 2)

\$725.....	Member
\$725.....	Cooperating Society
\$840.....	Non-Member
\$390.....	Student
\$425.....	Retired LIA Member

#### (August 3 – August 31)

\$775.....	Member
\$775.....	Cooperating Society
\$890.....	Non-Member
\$460.....	Student
\$475.....	Retired LIA Member

#### (September 1 – On-site)

\$825.....	Member
\$940.....	Non-Member

### One Day Conference Registration

#### Early Bird (payment received by August 2)

\$295.....	Member
\$325.....	Non-Member

#### (August 3 – August 31)

\$325.....	Member
\$355.....	Non-Member

#### (September 1 – On-site)

\$360.....	Member
\$390.....	Non-Member

### Laser Solutions Short Course Registration

#### Early Bird (payment received by August 2)

\$295.....	Member
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#### (August 3 – August 31)

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#### (September 1 – On-site)

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\*Single short course admission fee \$100 LIA Member and Non Member.

Purchase orders will not be accepted on-site.

Transportation from LAX airport to Anaheim Marriott is \$30.00 round trip, per person.

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## Sunday, September 23

- 8:00am ICALEO Registration Desk & LIA Bookstore Open
- 9:00am Laser Solutions Short Courses
- 11:30am LIA Board of Directors Meeting
- 4:00pm Welcome Celebration

## Monday, September 24

- 7:00am ICALEO Registration Desk & LIA Bookstore Open
- 7:30am Session Chair Appreciation Breakfast
- 8:00am Attendee Continental Breakfast
- 9:00am Plenary Session: Green Photonics and Recent Progress in Laser-Based Light Sources and Their Applications in Materials Processing
- 10:10am Morning Break

### Lunch on own

- 1:30pm LMP 1: Pulsating Topics in Laser Materials Processing
- LMF 1 (Joint with Nano Conference): World of Applications in Sub-Millimeter Scale Business Forum & Panel Discussion: Increasing the Role of Lasers in a Non-Laser World
- 2:50pm Afternoon Break
- 3:20pm LMP 2: Laser Drilling
- LMP 3: Laser Metal Deposition I
- LMF 2: Medical Devices and Biomedical Applications
- Nano 1: Laser Micro/Nano Processing
- 5:30pm President's Reception

## Tuesday, September 25

- 7:30am ICALEO Registration Desk & LIA Bookstore Open
- 8:00am Attendee Continental Breakfast
- 8:00am Poster Presentation Gallery
- 8:30am LMP 4: Laser Processing of CFRP
- LMP 5: Laser Metal Deposition II
- LMP 6: Process Monitoring & Control
- LMF 3: Innovative Laser Optics
- Nano 2: Laser-Material Interactions at Nanoscales
- 10:10am Morning Break

### Lunch on own

- 1:30pm LMP 7: Welding I
- LMP 8: Laser Cutting
- LMP 9: High Brightness Lasers & Systems
- LMF 4: Microwelding
- LMF 5: Processing of Transparent & Brittle Materials

- 2:50pm 10 Minute Intermission
- 4:00pm Laser Industry Vendor Reception & Tabletop Display

## Wednesday, September 26

- 7:30am ICALEO Registration Desk & LIA Bookstore Open
- 7:45am Attendee Breakfast/Poster Presentation Gallery Q & A
- 8:30am LMP 10: Welding II
- LMP 11: Processing of Dissimilar Materials
- LMF 6: Thin Film Processing
- LMF 7: Surface Modification I
- Nano 3: Thermal Characterization & Processing at Micro/Nanoscales
- 10:10am Morning Break
- 10:30am LMP 12: Laser Surface Modification I
- LMP 13: Hybrid & Combination Processes I
- LMF 8: Lasers in Energy Generation & Storage
- LMF 9: Surface Modification II
- Nano 4: Laser Nanolithography & Nanostructuring

### LIA Annual Meeting & Awards Luncheon

- 3:00pm LMP 14: Welding III
- LMP 15: Hybrid & Combination Process II
- LMP 16: Laser Metal Deposition III
- LMF 10: Modeling & Physical Interactions
- LMF 11: Monitoring & Detection
- 5:00pm Afternoon Break

## Thursday, September 27

- 7:30am ICALEO Registration Desk & LIA Bookstore Open
- 8:00am Attendee Continental Breakfast
- 8:30am LMP 17: Welding IV
- LMP 18: Laser Surface Modification II
- LMP 19: Modelling & Simulation
- LMF 12: Microprocessing & Drilling
- LMF 13: Advances in Laser Sources
- Nano 5: Laser Applications in Flexible Electronics
- 10:10am Morning Break

### Lunch on own

- 1:30pm Closing Plenary Session: Ways of Knowledge Transfer
- 3:50pm Farewell Break

\* Program subject to minor changes





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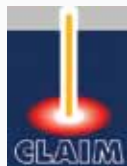
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